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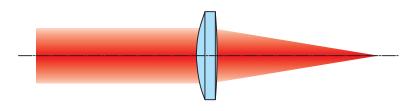
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The lens or a combination of these lenses found in this section will have limited applications compared with single spherical lens but very high performance can be achieved in a dedicated application.

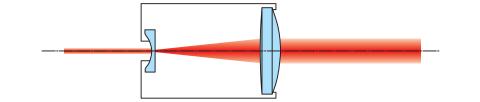
Beam Focusing

Туре	Features	Applications		
Achromatic Lens	Chromatic and spherical aberration is minimized. Large line-up of focal length and aperture.	Focus ability in low power lasers. Imaging system for infinity object		
Focusing Lens	High laser damage threshold Spot size is minimized and near to the diffraction limit.	Lens for various laser fabrication such as laser marking, cutting and welding.		
Objective Lens	Highly corrected lens with high magnification Large numerical aperture produces minimum spot size. Fully usable throughout the visible wavelength spectrum.	Microscopic imaging for the visible, ultra-violet and near infrared wavelength spectrum. Focusing a laser beam into a minimal spot. Micro-fabrication for lasers.		



Beam Expanding

Туре	Features	Applications		
Beam Expander	Optimized design for minimum spherical aberration Integrated design with reduced size	Magnifying the laser aperture (for interferometer and projection) Reducing the focal spot size (by enlarging the incident laser beam diameter)		
Spatial filter (objective lens) + Achromatic lens	Large choice of expansion ratios. Provides a high purified beam profile.	When using a very large collimated beam. When changing the beam aperture (with switching the achromatic lenses)		







Application Systems

Optics & Optical Coatings

> Opto-Mechanics

Manual Stages

Bases

Slayes

Actuators & Adjusters

Motoeized Stages

Light Sources & Laser Safety

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Achromatic Doublets DLB

entire visible wavelength spectrum.

wavelength (400 - 700nm).

minimize spherical aberration.

shorter focus than a paraxial focus.

Application Systems

Optics & Optical Coatings

Opto-Mechanics

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Polarizers

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Substrates/Windows

Ontical Data

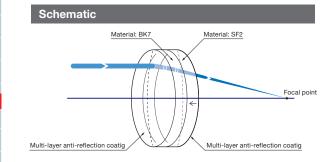
Maintenance

Lenses

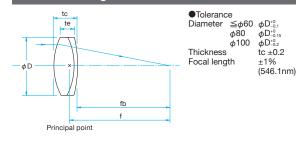
Filters

Prisms





Outline Drawing



BK7, SF2
Blue: 486.1nm, Green: 546.1nm, Red: 656.3nm
Broadband multi-layer anti-reflection coating for the Visible
Ultraviolet Hardened Adhesive
0.3J/cm ² (Laser pulse width 10ns, repetition frequency 20Hz)
40–20
90% of actual aperture

Guide

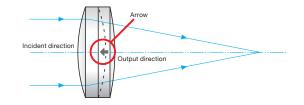
Achromatic doublets are cemented achromats made of two different lenses (Low dispersion positive from crown glass and high dispersion negative from flint glass). The difference of dispersion and shape of both lenses are designed to minimize the chromatic aberrations in blue

(486.1nm), green (546.1nm) and red (656.3nm). Therefore, these lenses are able to support the

- Please contact our Sales Division for customized achromatic doublets. (Customized on size etc.)
- Please refer to our web site for the lens design data. WEB Reference Catalog Code W3075
- Air spaced focusing lenses are also available (NYTL/NYDL) designed for laser processing applications. Reference B181

Attention

- Set the positive part to the side of the incident parallel beam and put the negative part to the side of the focal point to minimize spherical aberration.
- The difference in focal length of a lens at each wave length is Chromatic aberration and is due to "dispersion of the glass", the change in refractive index of glass accordding to wavelength. This can be corrected by combining glasses with low and high dispersions.
- Spherical aberration is when a ray enters a lens farther from its optical axis and has a shorter focus than a paraxial focus.
- Be sure to wear laser safety goggles when checking optical path and adjusting optical axis



Selection Guide Achromats

Focusing Lenses

fe Lenses

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Expanders

Others





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• The spherical aberration of achromatic doublets is better than singlets and minimized at infinite conjugate ratios. • Achromatic Doublets are coated on both surfaces with a broadband multi-layer anti-reflection coating for the visible • Set the positive part to the side of the incident parallel beam and put the negative part to the side of the focal point to • The difference in focal length of a lens at each wave length is Chromatic aberration and is due to "dispersion of the glass", the change in refractive index of glass accordding to wavelength. This can be corrected by combining glasses with low and high dispersions. Spherical aberration is when a ray enters a lens farther from its optical axis and has a

RoHS



φ 10 – φ 25							
Part Number	Diameter	Focal length	Edge Thickness te	Center Thickness tc	Back focal length fb	Centration [']	Application
DLB-10-20PM	[mm]	[mm] 	[mm] 5.1	[mm]	[mm]	<1	Systems
DLB-10-25PM	φ10 φ10	25.0	4.9	6.7	16.6 22.1	<1	Optics &
DLB-10-20PM	φ10 φ10	30.1	4.5	5.7	27.4	<1	Optical
DLB-10-30PM	φ10 φ10	40.0	4.6	5.3	37.5	<1	Coatings
DLB-10-40PM	φ10 φ10	50.0	4.0	5.0	47.5	<1	Opto-
DLB-10-60PM	φ10 φ10	60.1	4.4	4.9	57.6	<1	Mechanics
DLB-10-70PM	φ10 φ10	69.9	4.4	4.5	67.3	<1	
DLB-10-70PM	φ10 φ10	80.1	4.3	4.7	77.8	<1	Bases
DLB-10-00PM	φ10 φ10	100.5	4.2	4.5	98.1	<1	
DLB-12.7-25PM	φ12.7	25.1	5.3	7.3	21.5	<1	Manual
DLB-12.7-30PM	φ12.7	30.0	5.2	6.8	26.7	<1	Stages
DLB-12.7-40PM	φ12.7	40.1	4.9	6.1	36.9	<1	-
DLB-12.7-50PM	φ12.7	50.1	4.5	5.7	47.3	<1	Actuators &
DLB-12.7-60PM		60.0	4.6	5.4	57.3		Adjusters
	φ12.7 φ12.7	69.9	4.6	5.4	67.5	<1	
DLB-12.7-70PM DLB-12.7-80PM	φ12.7	79.9	4.5	5.2	77.4	<1 <1	Motoeized Stages
DLB-12.7-80PM DLB-12.7-100PM	φ12.7	100.1	4.5	4.8	97.9	<1	Stayes
DLB-12.7-100PM DLB-15-25PM				8.8	20.7		Light Sources &
DLB-15-23PM	φ15	25.2	6.0			<1	Laser Safety
DLB-15-30PM	φ15 ±15	30.1 40.1	5.7 5.2	8.0 6.9	26.0 36.5	<1 <1	
DLB-15-50PM	φ15 ±15	50.1	5.2	6.3	47.1		Index
DLB-15-60PM	φ15					<1	IIIdox
	φ15	59.9 70.2	4.8	5.9	57.0 67.4	<1	
DLB-15-70PM	φ15 φ15	70.2	4.8 4.7	5.7 5.5	77.1	<1 <1	
DLB-15-80PM DLB-15-100PM		100.0	4.7	5.2	97.3		Guide
DLB-13-100PM DLB-20-30PM	φ15			10.9		<1	Mirrors
DLB-20-30PM	φ20 ¢20	30.6 40.1	6.8 6.2	9.2	24.9 35.3	<1	WIIITOIS
DLB-20-40PM	¢20					<1	Beamsplitters
DLB-20-50PM DLB-20-60PM	φ20	50.2 60.2	5.7 5.4	8.1 7.4	46.0 56.6	<1	Polarizers
DLB-20-70PM	φ20	70.1	5.2	6.9	66.7	<1 <1	1010112015
DLB-20-80PM	φ20 ¢20	70.1	5.2	6.6	76.6		Lenses
DLB-20-100PM	¢20	99.5	4.9	6.1	96.4	<1 <1	Multi-Element Optics
DLB-20-100PM	φ20 +20	120.3	4.9	5.7			multi-Liencin optics
DLB-20-120PM	φ20				117.3	<1	Filters
	φ20	149.8	4.6	5.4	147.0	<1	Prisms
DLB-20-170PM	¢20	170.0	4.6	5.3	167.2	<1	1 113113
DLB-20-200PM DLB-20-220PM	φ20 +20	200.1	4.5	5.1	197.3	<1	Substrates/Windows
DLB-20-250PM	φ20	220.0	4.5	5.0	216.9	<3	Optical Data
	φ20 ¢20	250.0	4.4	4.9	247.0	<3	optiour butu
DLB-20-300PM	φ20	300.0	4.3	4.7	297.1	<3	Maintenance
DLB-25-40PM	φ25 ±25	40.9		12.5	34.2	<1	
DLB-25-50PM	φ25	50.1	7.1	10.9	44.9	<1	
DLB-25-60PM	φ25 φ25	60.1	6.7	9.8	55.2	<1	Selection Guide
DLB-25-70PM	φ25 φ25	69.9 80.0	6.3	9.0	65.3	<1	Achromats
DLB-25-80PM	φ25 ¢25	80.0	6.2	8.5 7.7	75.9	<1	Focusing Lenses
DLB-25-100PM	φ25	100.2	5.9		96.5	<1	
DLB-25-120PM	φ25 φ25	119.8	5.6	7.2	116.2	<1	fe Lenses
DLB-25-150PM	φ25 ¢25	149.6	5.5	6.7	146.2	<1	Objectives
DLB-25-170PM	φ25 	170.4	5.3	6.4	167.1	<1	Expanders
DLB-25-200PM	φ25	200.1	5.2	6.1	197.0	<1	Others
DLB-25-220PM	φ25	222.0	5.2	6.0	218.9	<1	ouicra
DLB-25-250PM	φ25	250.8	5.1	5.8	247.7	<1	
DLB-25-300PM	φ25	300.0	5.0	5.6	296.6	<3	

Compatible Optic Mounts

LHF-10S, -15S, -20S, -25S / LHA-25

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tics



Achromatic Doublets DLB

Catalog W3076

	φ 25.4 – φ 40						
Application Systems	Part Number	Diameter	Focal length f [mm]	Edge Thickness te [mm]	Center Thickness tc [mm]	Back focal length fb [mm]	Centration [']
Systems	DLB-25.4-40PM	φ25.4	50.1	7.0	10.9	44.9	<1
Optics &	DLB-25.4-50PM	φ25.4	50.1	7.0	10.9	44.9	<1
Optical Coatings	DLB-25.4-60PM	¢25.4	60.1	6.6	9.8	55.2	<1
j -	DLB-25.4-70PM	φ25.4	69.9	6.2	9.0	65.3	<1
Opto- Mechanics	DLB-25.4-80PM	φ25.4	80.0	6.1	8.5	75.9	<1
wechanics	DLB-25.4-100PM	φ25.4	100.2	5.8	7.7	96.5	<1
	DLB-25.4-120PM	φ25.4	119.8	5.6	7.2	116.2	<1
Bases	DLB-25.4-150PM	φ25.4	149.6	5.4	6.7	146.2	<1
	DLB-25.4-170PM	φ25.4	170.4	5.3	6.4	167.1	<1
Manual	DLB-25.4-200PM	φ25.4	200.1	5.1	6.1	197.0	<1
Stages	DLB-25.4-220PM	φ25.4	222.0	5.1	6.0	218.9	<1
	DLB-25.4-250PM	φ25.4	250.8	5.0	5.8	247.7	<1
Actuators & Adjusters	DLB-25.4-300PM	φ25.4	300.0	5.0	5.6	296.6	<3
. Lajuotoro	DLB-30-50PM	φ30	50.3	8.6	14.1	43.5	<1
Motoeized	DLB-30-60PM	φ30	60.3	8.1	12.6	53.9	<1
Stages	DLB-30-70PM	φ30	70.8	7.7	11.5	65.0	<1
	DLB-30-80PM	φ30	80.3	7.4	10.7	75.0	<1
Light Sources &	DLB-30-100PM	φ30	100.7	6.8	9.5	96.0	<1
Laser Safety	DLB-30-120PM	<i>\$</i> 30	120.1	6.6	8.8	115.7	<1
	DLB-30-150PM	φ30	150.0	6.3	8.1	146.0	<1
Index	DLB-30-170PM	φ30	169.9	6.1	7.7	166.0	<1
	DLB-30-200PM	φ30	200.2	6.0	7.3	196.4	<1
	DLB-30-220PM	<i>\$</i> 30	220.2	5.9	7.1	216.5	<1
Guide	DLB-30-250PM	φ30	249.7	5.8	6.9	246.1	<1
unuc	DLB-30-300PM	φ30	300.4	5.7	6.6	296.9	<1
Mirrors	DLB-30-350PM	<i>ф</i> 30	350.0	5.6	6.4	346.2	<3
Beamsplitters	DLB-30-400PM	<i>ф</i> 30	400.0	5.5	6.2	396.3	<3
Doumophicoro	DLB-30-450PM	φ30	450.0	5.5	6.1	446.5	<3
Polarizers	DLB-30-500PM	φ30	500.0	5.5	6.0	496.5	<3
Lenses	DLB-40-60PM	<i>φ</i> 40	60.2	11.0	19.3	50.2	<1
	DLB-40-70PM	φ40	70.3	10.2	17.2	61.7	<1
Multi-Element Optics	DLB-40-80PM	φ40	80.2	9.7	15.8	71.8	<1
Filters	DLB-40-100PM	φ40	99.9	8.9	13.7	92.8	<1
	DLB-40-120PM	φ40	120.0	8.3	12.3	113.7	<1
Prisms	DLB-40-150PM	φ40	150.1	7.7	10.9	144.5	<1
Substrates/Windows	DLB-40-170PM	φ40	169.7	7.5	10.3	164.5	<1
	DLB-40-200PM	φ40	199.7	7.2	9.6	194.8	<1
Optical Data	DLB-40-220PM	φ40	220.7	7.0	9.2	216.0	<1
Maintenance	DLB-40-250PM	<i>φ</i> 40	249.1	6.9	8.8	244.6	<1
	DLB-40-300PM	φ40	300.5	6.7	8.3	296.1	<1
	DLB-40-350PM	φ40	349.9	6.5	7.9	345.8	<1
Selection Guide	DLB-40-400PM	<i>φ</i> 40	399.7	6.4	7.6	395.7	<1
Achromats	DLB-40-450PM	<i>φ</i> 40	450.0	6.3	7.4	445.5	<3
Aviii viilatə	DLB-40-500PM	φ40	500.0	6.3	7.2	495.6	<3

Focusing Lenses

fe Lenses

Objectives

Expanders

Others

Compatible Optic Mounts

LHF-25.4S, -30AS, -40AS



60

φ 50 – φ 100							
Part Number	Diameter <i>p</i> D	Focal length	Edge Thickness te	Center Thickness tc	Back focal length fb	Centration	Annlingtion
i art Number	φD [mm]	[mm]	[mm]	[mm]	[mm]	[']	Application Systems
DLB-50-80PM	φ50	81.0	13.4	22.9	69.1	<1	-
DLB-50-100PM	φ50	100.5	12.3	19.9	90.0	<1	Optics & Optical
DLB-50-120PM	φ50	120.2	11.4	17.7	111.0	<1	Coatings
DLB-50-150PM	φ50	150.7	10.5	15.5	142.8	<1	
DLB-50-170PM	φ50	169.8	10.1	14.5	162.5	<1	Opto- Mechanics
DLB-50-200PM	φ50	200.1	9.6	13.3	193.3	<1	Weenames
DLB-50-220PM	φ50	220.7	9.3	12.7	214.5	<1	
DLB-50-250PM	φ50	249.4	9.1	12.1	243.4	<1	Bases
DLB-50-300PM	φ50	299.5	8.7	11.2	293.7	<1	
DLB-50-350PM	φ50	350.2	8.6	10.7	344.5	<1	Manual
DLB-50-400PM	φ50	400.0	8.3	10.2	394.7	<1	Stages
DLB-50-450PM	φ50	451.5	8.3	9.9	446.2	<1	
DLB-50-500PM	φ50	500.3	8.1	9.6	495.2	<1	Actuators & Adjusters
DLB-50-600PM	φ50	599.9	8.0	9.2	594.4	<3	Aujusters
DLB-50-700PM	φ50	700.0	7.8	8.9	694.6	<3	Motoeized
DLB-50-800PM	φ50	800.0	7.7	8.6	794.9	<3	Stages
DLB-50-1000PM	φ50	1000.0	7.6	8.3	995.0	<3	
DLB-50.8-100PM	φ50.8	100.5	12.1	19.9	90.0	<1	Light Sources &
DLB-50.8-120PM	φ50.8	120.2	11.2	17.7	111.0	<1	Laser Safety
DLB-50.8-150PM	φ50.8	150.7	10.4	15.5	142.8	<1	
DLB-50.8-200PM	φ50.8	200.1	9.5	13.3	193.3	<1	Index
DLB-50.8-250PM	φ50.8	249.4	9.0	12.1	243.4	<1	
DLB-50.8-300PM	φ50.8	299.5	8.6	11.2	293.7	<1	
DLB-50.8-400PM	φ50.8	400.0	8.3	10.2	394.7	<1	Guide
DLB-50.8-500PM	φ50.8	500.3	8.1	9.6	495.2	<1	Guide
DLB-50.8-700PM	φ50.8	700.0	7.8	8.9	694.6	<3	Mirrors
DLB-50.8-1000PM	φ50.8	1000.0	7.5	8.3	995.1	<3	Deemenlittere
DLB-60-170PM	<i>φ</i> 60	170.8	11.4	17.7	161.9	<1	Beamsplitters
DLB-60-200PM	<i>φ</i> 60	200.3	10.7	16.1	192.1	<1	Polarizers
DLB-60-250PM	<i>ф</i> 60	250.0	10.0	14.3	242.8	<1	Longoo
DLB-60-500PM	<i>ф</i> 60	499.1	8.6	10.7	493.5	<1	Lenses
DLB-60-600PM	<i>φ</i> 60	597.9	8.3	10.1	592.6	<1	Multi-Element Optics
DLB-80-150PM	φ80	149.7	17.2	30.3	133.6	<1	Filters
DLB-80-200PM	φ80	200.8	14.7	24.3	188.2	<1	Fillers
DLB-80-300PM	φ80	299.8	12.4	18.8	290.2	<1	Prisms
DLB-80-500PM	φ80	502.6	10.7	14.5	494.9	<1	Cubetrates /Mindows
DLB-80-800PM	φ80	800.6	9.7	12.1	794.2	<1	Substrates/Windows
DLB-100-200PM	<i>φ</i> 100	200.6	21.8	37.0	181.0	<1	Optical Data
DLB-100-300PM	<i>φ</i> 100	297.3	18.0	28.0	283.2	<1	Mointononoo
DLB-100-500PM	φ100	499.6	15.2	21.1	488.8	<1	Maintenance
DLB-100-800PM	φ100	799.5	13.7	17.4	790.4	<1	
DLB-100-1000PM	φ100	998.1	13.1	16.1	989.7	<1	Selection Guide

Achromats

Focusing Lenses fe Lenses Objectives

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Compatible Optic Mounts

LHF-50S, -50.8S, -60S, -80, -100



Optics & Optical Coatings

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Focusing Lenses

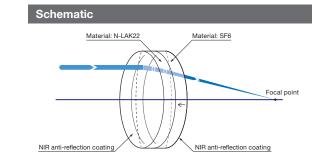
fe Lenses

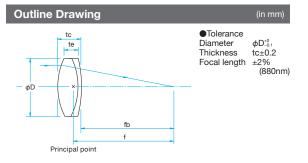
Objectives

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Specifications Material N-LAK22, SF6 Design wavelength 700nm, 880nm, 1100nm Coating Multi-layer anti-reflection coating (700 - 1550nm) Cement Ultraviolet Hardened Adhesive Laser Damage Threshold 0.3J/cm² Surface Quality (Scratch-Dig) 40-20 Clear aperture 90% of actual aperture

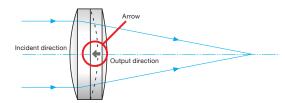
RoHS

Catalog W3195

- For product other diameter size or focal lengths which are not listed. on our website or in our catalog, please contact our Sales Division
- The design and manufacture of achromatic lens of other wavelength
- available. Reference B182

Attention

- Please use achromatic lens when focusing an image at infinity or when making parallel light from the one point of light source. It does not provide sufficient optical performance when used in such as short-range distance imaging.
- There is a direction to the incident light parallel to the achromatic lens. A surface with a small radius of curvature is allowed to be incident parallel light from a rear surface (the surface the arrow is pointing to). When it is incident parallel light from the opposite side. spherical aberration and chromatic aberration will occur and the focused spot size will increase.
- When used in the visible region, spherical aberration and chromatic aberration increases. In addition, the transmittance decreases.



Specifications								
Part Number	Diameter φD [mm]	Focal length f [mm]	Edge Thickness te [mm]	Center Thickness tc [mm]	Back focal length fb [mm]	Centration [']		
DL-15-20PNIR	φ15	19.9	6.6	9.5	14.7	<3		
DL-15-25PNIR	φ15	25.0	5.8	8.1	20.6	<3		
DL-15-30PNIR	φ15	30.1	5.6	7.4	26.0	<3		
DL-15-50PNIR	φ15	50.2	4.9	5.9	46.8	<3		
DL-25-30PNIR	φ25	30.0	10.8	16.3	21.4	<3		
DL-25-40PNIR	φ25	40.1	9.3	13.2	32.8	<3		
DL-25-50PNIR	φ25	50.2	8.5	11.6	43.8	<3		
DL-25-100PNIR	φ25	100.4	7.2	8.7	95.1	<3		

Compatible Optic Mounts

LHE-158 -258

B176

Near Infrared Achromatic Lens **DL-PNIR**

By bonding two lenses with wavelength dispersion of different refractive index the resulting component will provide reduced spherical aberration and chromatic aberration than that of a single spherical lens.

These achromatic lenses can be used as a focusing lens for YAG laser (1064nm) or LD of the nearinfrared.

• The lens design is optimized so that the focal length change is minimized in the near infrared region. The focal length

• It is suitable as a collimating lens not only because chromatic aberration but also spherical aberration is collected.

matches at 700nm, 880nm, 1100nm wavelengths and is optimized to minimize aberrations.

Guide

- with your requests.
- bands are available upon requested.
- Focusing Lenses for Fiber Lasers (HFTLSQ/HFDLSQ) are also

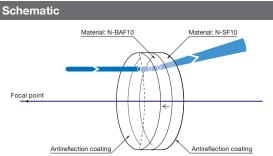


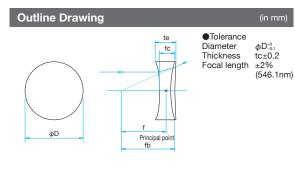
It is achromatic lens having a negative focal length.

By setting the concave one bonding two lenses wavelength dispersion of the refractive index is different, can be smaller than the spherical single lens and spherical aberration and chromatic aberration.

- It is optimized focal length shift is small in the visible light range, the aberration is minimized.
- It can be the beam expander of Galileo type in combination with achromatic lens with a focal length of the positive.







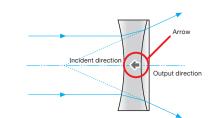
Specifications					
Material	N-BAF10, N-SF10				
Design wavelength	486.1nm, 546.1nm, 656.3nm				
Coating	Antireflection coating				
Cement	Ultraviolet Hardened Adhesive				
Laser Damage Threshold	0.3J/cm ²				
Surface Quality (Scratch–Dig)	40–20				
Clear aperture	90% of actual aperture				

Guide

► For custom focal lengths and diameter sizes not listed on-line or in our catalog please contact our Sales Division.

Attention

- There is a direction to the incident parallel light to the achromatic lens. A surface with a small radius of curvature is allowed to be incident parallel light from a rear surface (the surface on the arrow is pointing to). When it is incident parallel light from the opposite side, spherical aberration and chromatic aberration will occur.
- When used in the visible region, spherical aberration and chromatic aberration increases. In addition, the transmittance decreases.



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Specifications						
Part Number	Diameter	Focal length f [mm]	Edge Thickness te [mm]	Center Thickness tc [mm]	Back focal length fb [mm]	Centration [′]
DL-25-50NM	φ25	-49.94	9.3	6.7	-53.1	<3
DL-25-100NM	φ25	-99.94	5.9	4.6	-102.3	<3

Compatible Optic Mounts

LHF-25S



Reasonable Achromatic Lens S-DLB



An economic general use achromatic lens suitable for an optical system, which does not require high surface quality imaging such as a microscope lens or telescope lens.

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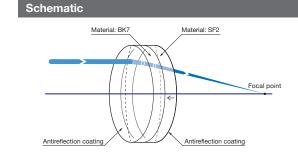
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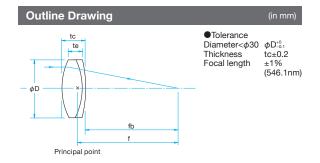
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Part Number	Diameter ØD [mm]	Focal length f [mm]	Edge Thickness te [mm]	Center Thickness tc [mm]	Back foc length fb [mm]
S-DLB-10-20PM	φ10	20.0	5.1	6.7	16.6
S-DLB-10-25PM	φ10	25.0	4.9	6.1	22.1
S-DLB-10-40PM	φ10	40.0	4.6	5.3	37.5
S-DLB-10-50PM	φ10	50.0	4.4	5.0	47.5
S-DLB-10-100PM	φ10	100.5	4.2	4.5	98.1
S-DLB-15-25PM	φ15	25.2	6.0	8.8	20.7
S-DLB-15-30PM	φ15	30.1	5.7	8.0	26.0
S-DLB-15-40PM	φ15	40.1	5.2	6.9	36.5
S-DLB-15-50PM	φ15	50.1	5.0	6.3	47.1
S-DLB-15-80PM	φ15	79.9	4.7	5.5	77.1
S-DLB-15-100PM	φ15	100.0	4.5	5.2	97.3
S-DLB-20-30PM	φ20	30.6	6.8	10.9	24.9
S-DLB-20-40PM	φ20	40.1	6.2	9.2	35.3
S-DLB-20-50PM	φ20	50.2	5.7	8.1	46.0
S-DLB-20-60PM	φ20	60.2	5.4	7.4	56.6
S-DLB-20-70PM	φ20	70.1	5.2	6.9	66.7
S-DLB-20-80PM	φ20	79.9	5.1	6.6	76.6
S-DLB-20-100PM	φ20	99.5	4.9	6.1	96.4
S-DLB-20-120PM	φ20	120.3	4.7	5.7	117.3
S-DLB-20-150PM	φ20	149.8	4.6	5.4	147.0
S-DLB-20-200PM	φ20	200.1	4.5	5.1	197.3

Compatible Optic Mounts

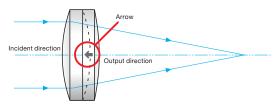
LHF-10S, -15S, -20S, -25S, -30S

- Specification except surface quality is almost the same as DLB series. Except when used in high-precision experiment using a laser, this lens is recommended.
- It is optimized so that focal length gap is small in the visible light range and the aberration is minimized.

Specifications	
Material	BK7, SF2
Design wavelength	Blue: 486.1nm, Green: 546.1nm, Red: 656.3nm
Centration	<3′
Cement	Ultraviolet Hardened Adhesive
Coating	Antireflection coating
Surface Quality (Scratch–Dig)	60–40
Clear aperture	90% of actual aperture
Laser Damage Threshold	0.3J/cm ² (Laser pulse width 10ns, repetition frequency 20Hz)

Attention

- Achromatic lens is used when focusing an image at infinity or when making the point light source to collimated light. It does not provide sufficient optical performance when used in such as short-range imaging.
- ► There is a direction of the incident parallel light with achromatic lens. The radius of curvature is allowed to be incident parallel light from the side of (the surface indicated by arrows) small curvature surface. If the parallel light incidents from the opposite side, then spherical aberration and chromatic aberration occur and the focused spot size will be large.

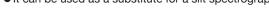


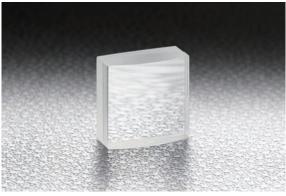
φ 25 – φ 30					
Part Number	Diameter <i>φ</i> D [mm]	Focal length f [mm]	Edge Thickness te [mm]	Center Thickness tc [mm]	Back focal length fb [mm]
S-DLB-25-50PM	φ25	50.1	7.1	10.9	44.9
S-DLB-25-70PM	φ25	69.9	6.3	9.0	65.3
S-DLB-25-100PM	φ25	100.2	5.9	7.7	96.5
S-DLB-25-120PM	φ25	119.8	5.6	7.2	116.2
S-DLB-25-150PM	φ25	149.6	5.5	6.7	146.2
S-DLB-30-60PM	φ30	60.3	8.1	12.6	53.9
S-DLB-30-100PM	φ30	100.7	6.8	9.5	96.0
S-DLB-30-120PM	φ30	120.1	6.6	8.8	115.7
S-DLB-30-150PM	φ30	150.0	6.3	8.1	146.0
S-DLB-30-200PM	φ30	200.2	6.0	7.3	196.4
S-DLB-30-300PM	φ30	300.4	5.7	6.6	296.9



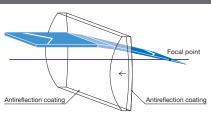
A cylindrical achromat is single component made by bonding two cylindrical surface lenses having different refractive indexes. The resulting achromat creates fine lines close to the theoretical limit. The cylindrical achromat is recommended if blurred lines and color bleeding is a concern when using cylindrical plano-convex lens (CLB-P).

- It is designed so that difference of focusing point is reduced as much as possible in the visible light range.
- Optical adjustment is easy to do as direction of the condenser line will be parallel to the side of the diameter (B). • It can be used as a substitute for a slit spectrograph.

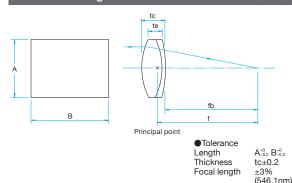




Schematic



Outline Drawing



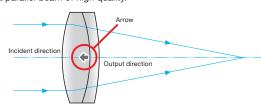
N-SF5, BK7
Blue: 486.1nm, Green: 546.1nm, Red: 656.3nm
Antireflection coating
Ultraviolet cure adhesive
0.3J/cm ² (Laser pulse width 10ns, repetition frequency 20Hz)
60-40
Circle that internally connected to 90% of the side length

Guide

- Cylindrical lens holder (CHA) is available for mounting the achromatic

Attention

- There is a direction of the incident parallel light with achromatic cylinder lens. The radius of curvature is allowed to be incident parallel light from the side of (the surface indicated by arrows) small curvature surface. If it is incident parallel light from the opposite side, condensing line will be thick
- In the generatrix direction (B direction), there is no characteristic to reduce the effect of achromatic, reducing aberration, and for collecting light.
- If it is incident line beam source into achromatic cylindrical lens, parallel light does not come out. It will diverge in the direction of the generatrix (B direction).
- In order to focus the fine beam line, it is necessary to enter the lens a parallel beam of high quality.



Specifications					
Part Number	A×B [mm]	Focal length f [mm]	Edge Thickness te [mm]	Center Thickness tc [mm]	Back focal length fb [mm]
CDL-1515-25PM	15×15	25.0	6.4	9.0	18.2
CDL-1515-50PM	15×15	50.0	4.7	6.0	46.4
CDL-1515-100PM	15×15	100.0	4.3	5.0	97.1

Compatible Optic Mounts

CHA-25

Different focal length and diameters not mentioned on-line or in our catalog are available as a custom product upon on request.

cylinder lens. WEB Reference Catalog Code W4022

Expanders Others

WEB http://www.sigma-koki.com/english/ E-mail international@sigma-koki.com TEL +81-3-5638-8228 FAX +81-3-5638-6550

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Visible Spectrum Achromats

ATL/NADL



Visible spectrum achromats are air spaced achromatic triplets or doublets for lasers in the visible spectrum or white light applications.

The elements are made of crown glass of low dispersion and flint glass of high dispersion.

- These lenses have been optimized for achromatic and spherical aberrations and coma for the 3 wavelengths; blue (486.1nm), green (546.1nm) and red (656.3nm). They are coated with a broadband multi-layer anti-reflection coating for 400 - 700nm.
 - Air spaced design allows high power laser applications which includes YAG second harmonic wavelength (532nm).
 - The triplets with F-numbers ≥ 2 and doublets with F-numbers ≥ 3 are designed to have each spot size equal to the diffraction limited spot size and very ideal for a Gaussian input beam.



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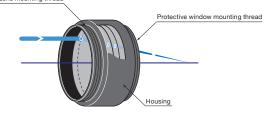
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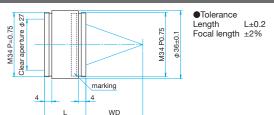


Schematic

Lens mounting thread



Outline Drawing



Specifications Material Crown Glass - (Air spaced) - Flint Glass Material of frame Aluminum Finishing: Black anodized 486nm, 532nm, 656nm Design wavelength Coating Broadband multil-aver anti-reflection coating $+1^{\circ}$ Acceptance angle 1J/cm² Laser Damage Threshold (Laser pulse width 10ns, repetition frequency 20Hz)

Guide

- Please contact our Sales Division for customized achromats. (Customized on size etc.)
- Protective lens case with rods for mirror holders is available as an option. Please contact us for further information.
- Please check the "wavelength characteristic of the focal length data" on the Web for the focal lengths of each wavelength. WEB Reference Catalog Code W3078

Attention

- Since the focal length and working distance of the lens is calculated at 532nm, it will change at other wavelengths due to the refractive index of the material shift.
- The F number of a lens is calculated by f (effective focal length) / De (effective clear aperture). The value represents "Brightness of the lens". The lower the value, the brighter the lens is.
- Be sure to wear laser safety goggles when checking optical path and adjusting optical axis.

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Specifications				
Part Number	Focal length f [mm]	Length L [mm]	Numerical aperture (NA)	Working distance (WD) [mm]
ATL-30-40PY2	40.2	22	0.34	30.1
ATL-30-50PY2	49.4	22	0.27	39.0
ATL-30-60PY2	58.9	22	0.23	49.0
NADL-30-80PY2	80.1	13	0.17	71.8
NADL-30-100PY2	99.8	13	0.14	91.9
NADL-30-150PY2	150.0	12	0.09	142.1
NADL-30-200PY2	199.8	12	0.07	193.1

Compatible Optic Mounts

I HF-M34-30

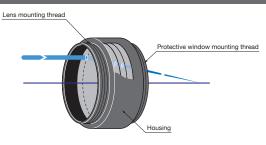


YAG laser focusing lenses are air spaced triplets or doublets for YAG wavelengths. The elements are made of crown glass of lower dispersion and flint glass of higher dispersion. These lenses are optimized for spherical aberration and coma. With its spot size designed to be smaller than or equal to the diffraction limited spot size for beams at 1064nm.

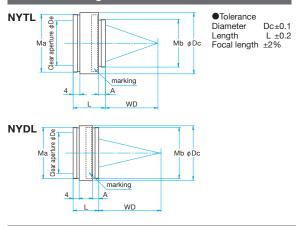
- These lenses are chromatically corrected so that any HeNe guided beam or visible video monitor beam will remain focused in the same position as the YAG beam. All elements are coated with a laser-resistant narrowband multi-layer anti-reflection for YAG: 1064nm and HeNe: 633nm.
- We offer optical protective windows to prevent damage to the lens by absorbing high levels of energy from inadvertent back reflection of the incident beam. These protective windows can be easily installed to the focusing side of the lens.



Schematic



Outline Drawing



Part Number	Maximum lens diameter φD [mm]	Focal length f [mm]	Diameter øDc [mm]	Clear aperture ØDe [mm]	Length L [mm]	Lens mounting thread Ma	Protective window thread Mb	Thread length A [mm]	Numerical aperture (NA)	Working distance (WD) [mm]
NYTL-25-20PY1	φ25	20.0	φ32	φ20	22	M29 P0.75	M22 P0.75	6.0	0.50	9.0
NYTL-30-30PY1	<i>\$</i> 30	30.0	φ36	φ27	22	M34 P0.75	M28 P0.75	6.5	0.45	19.1
NYTL-30-40PY1	<i>φ</i> 30	40.0	φ36	φ26.5	19	M34 P0.75	M28 P0.75	4.0	0.33	30.9
NYTL-30-50PY1	<i>\$</i> 30	50.0	φ36	φ25.5	19	M34 P0.75	M28 P0.75	3.5	0.25	41.4
NYDL-30-60PY1	φ30	59.9	φ36	φ27	17	M34 P0.75	M34 P0.75	4.0	0.23	41.1
NYDL-30-80PY1	<i>\$</i> 30	79.9	φ36	φ27	15	M34 P0.75	M34 P0.75	4.0	0.17	67.6
NYDL-30-100PY1	<i>\$</i> 30	100.1	φ36	φ27	14	M34 P0.75	M34 P0.75	4.0	0.14	88.4
NYDL-30-150PY1	φ30	149.3	φ36	φ27	12	M34 P0.75	M34 P0.75	4.0	0.09	140.0

Compatible Optic Mounts

LHF-M29-25, LHF-M34-30

Specifications Material Crown Glass - (Air spaced) - Flint Glass Material of frame Aluminum Finishing: Black anodized Design wavelength 1064nm, 632.8nm Coating Narrow band multi-layer anti-reflection coatig for 1064nm and 633nm Acceptance angle ±1° Laser Damage Threshold 1//cm² (Laser pulse width 10ns, repetition frequency 20Hz)

Guide

- Please contact our Sales Division for customized products. (Customized on size etc.)
- Please check the "wavelength characteristic of the focal length data" on the Web for the focal lengths of each wavelength.
 WEB Reference Catalog Code W3079

Attention

- Since the focal length and working distance of the lens is calculated at 1064nm, it will change at other wavelengths due to the refractive index of the material shift.
- ► The F number of a lens is calculated by f (effective focal length) / De (effective clear aperture). The value represents "Brightness of the lens". The lower the value, the brighter the lens is.
- Be sure to wear laser safety goggles when checking optical path and adjusting optical axis.

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Focusing Lenses for Fiber Lasers HFTLSQ/HFDLSQ



High performance multi-element focusing lens. They are suitable for focusing and collimating solid state lasers like Yb fiber laser, YAG laser and YVO4 laser.

- Engineered and designed to reduce the effects of thermal expansion.
- Corrected for spherical aberration and coma at 1064nm. Diffraction limited for F number ≥2 (NA≥0.25)
- AR coating optimized from 1040 1150nm with transmission at 633nm for pointed lasers

ow mounting thread

Dc±0.1

L ±0.2



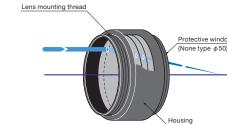
Specifications	
Material	Synthetic fused silica
Material of frame	Aluminum Finishing: Black anodized
Design wavelength	1064nm
Coating	Broadband multil-ayer anti-reflection coating
Transmittance	>98.5% (1060 – 1080nm) >97% (1040 – 1150nm) >53% (600 – 700nm)
Laser Damage Threshold	7J/cm ² (Laser pulse width 10ns, repetition frequency 20Hz)

Guide

Please contact our Sales Division for customized products. (Customized on size etc.)

Attention

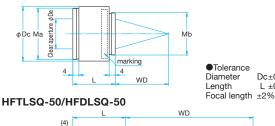
- Be sure to wear laser safety goggles when checking optical path and adjusting optical axis.
- Protective window as an option is not Anti-reflection coated.
- Incident a beam from the side with the screw.

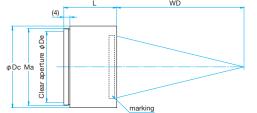


Outline Drawing

Schematic

HFTLSQ-15/HFTLSQ-20/HFTLSQ-30/HFDLSQ-30





Drawing of adapter for HFTLSQ-15-20PF1





Achromats **Focusing Lenses**

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Specifications									
Part Number	Focal length f [mm]	Diameter øDc [mm]	Clear aperture øDe [mm]	Length L [mm]	Lens mounting thread Ma	Protective window thread Mb	Numerical aperture (NA)	Working distance (WD) [mm]	Acceptance angle [°]
HFTLSQ-15-20PF1	20.0	φ24	φ12	16	M22 P0.75	M22 P0.75	0.30	13.7	±1.8
HFTLSQ-20-30PF1	30.3	φ30	φ17	21	M28 P0.75	M28 P0.75	0.28	22.0	±1.2
HFTLSQ-30-40PF1	40.0	φ36	φ27	31	M34 P0.75	M28 P0.75	0.34	24.9	±1
HFTLSQ-30-50PF1	50.0	φ36	φ27	28	M34 P0.75	M28 P0.75	0.27	35.4	±1
HFTLSQ-30-60PF1	60.1	φ36	φ27	23	M34 P0.75	M34 P0.75	0.22	51.4	±1
HFTLSQ-30-80PF1	80.0	φ36	φ27	23	M34 P0.75	M34 P0.75	0.17	71.7	±1
HFTLSQ-30-100PF1	100.0	φ36	φ27	23	M34 P0.75	M34 P0.75	0.14	92.7	±1
HFDLSQ-30-150PF1	150.0	φ36	φ27	18	M34 P0.75	M34 P0.75	0.09	131.0	±1
HFTLSQ-50-100PF1	99.9	φ54	φ47	35	M50.9 P0.75	-	0.24	84.2	±1
HFDLSQ-50-200PF1	199.6	φ54	φ47	23	M50.9 P0.75	—	0.12	185.7	±1
HFDLSQ-50-300PF1	300.0	φ54	φ47	23	M50.9 P0.75	-	0.08	286.2	±1

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Guide & Attention

assistance.

reduce transmittance to 90%.

transmittance performance.





PG / PGH

 Protective windows can be attached to the focusing lens to minimize damage from laser fabrication.
 The protective window comes in 3 different sizes.
 Protective Window Holders (PGH)

Visible Spectrum Achromats

YAG Laser Focusing Lenses



1±0.3 Both sides: Uncoated

Part Number	φD [mm]	Protective window retainer		
PG-21	φ21	PGH-24		
PG-27	φ27	PGH-30		
PG-33	<i>φ</i> 33	PGH-36		

LHF

Please select a fixed lens holder and a protective window that matches the profile of the focusing lens. (use the matrix table on the right)

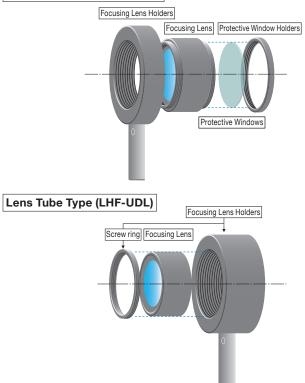
• There are two types of fixed holder for the focusing lens. WEB Reference Catalog Code W4023

Thread Mount Type (LHF-M)

- Visible Spectrum Achromats
- YAG Laser Focusing Lenses
- Focusing Lenses for Fiber Laser
- Excimer Laser Focusing Lenses (some models)

Lens Tube Type (LHF-UDL) Ultraviolet Achromats

Thread Mount Type (LHF-M)



Protective Window Holders (Retainer only) Material: Aluminum Finish: Black anodized 0.5 4.5 øΒ Protective window diameter Μ фC Part Number [mm] [mm] [mm] [mm] PGH-24 M22 P0.75 φ18 φ24 φ21 PGH-30 M28 P0.75 φ23 φ30 φ27 **PGH-36** M34 P0 75 φ29 φ36 φ33

Since protective windows are uncoated, surface reflections will

Anti-reflection coating for specific wavelength are available to

improve trasmittance, please contact our Sales Division for

Replace protective window if it is damaged or there is poor

List of adaptive lens	holder	and prot	tective window
Part Number	Protective window	Protective window retainer	Compatible Optic Mounts
Visible Spectrum Ach	iromats	5	
ATL-30-40PY2			
ATL-30-50PY2]		
ATL-30-60PY2	1		
NADL-30-80PY2	PG-33	PGH-36	LHF-M34-30
NADL-30-100PY2			
NADL-30-150PY2	1		
NADL-30-200PY2			
YAG Laser Focusing NYTL-25-20PY1	PG-21	PGH-24	LHF-M29-25
NTIL-20-20PTI	PG-21	PGH-24	LHF-10129-25
NYTL-30-30PY1	00 07		
NYTL-30-40PY1	PG-27	PGH-30	
NYTL-30-50PY1			
NYDL-30-60PY1			LHF-M34-30
NYDL-30-80PY1	00.33	PGH-36	
NYDL-30-100PY1	1 0 00	i an ou	
NYDL-30-150PY1			
Focusing Lenses for	Fiber L	aser	
HFTLSQ-15-20PF1	(PG-21)	PGH-24	exclusive adapter + LHF-M29-25
HFTLSQ-20-30PF1			exclusive adapter + LHF-M34-30
HFTLSQ-30-40PF1	(PG-27)	PGH-30	
HFTLSQ-30-50PF1	1` ´I		
HFTLSQ-30-60PF1			
HFTLSQ-30-80PF1			LHF-M34-30
HFTLSQ-30-100PF1	(PG-33)	PGH-36	
HFDLSQ-30-150PF1	1		
HFTLSQ-50-100PF1	\sim		
HFDLSQ-50-200PF1		\checkmark	LHF-M50.9-50
HFDLSQ-50-300PF1			
Excimer Laser Focus	ing Ler	ISAS	
ETL-30-40P		1000	
ETL-30-50P			
ETL-30-60P			
ETL-30-80P	(PG-33)	PGH-36	LHF-M34-30
	(FG-33)	FGH-50	LI II -10134-30
NEDL-30-100P			
NEDL-30-150P			
NEDL-30-200P	\vdash		
EDL-50-100P			
EDL-50-150P			
EDL-50-200P			LHF-M50.9-50
EDL-50-250P			
EDL-50-300P			
Ultraviolet Achromate	S		
UDL-30-50P	1	/	
UDL-30-80P			
UDL-30-100P			LHF-UDL-30
NUDL-30-150P			
NUDL-30-200P			
UDL-40-80P			
NUDL-40-100P	1)	\backslash	
NUDL-40-150P		Х	LHF-UDL-40
NUDL-40-200P	/	/ \	
NUDL-40-250P	. /	\backslash	
UDL-50-100P	. /	\	
NUDL-50-150P		\	
NUDL-50-200P	/	\	LHF-UDL-50
NUDL-50-250P	/	\ \	
NUDL-50-300P	/		
As for the protective wind	hows on	closed in r	parentheses, glass material

As for the protective windows enclosed in parentheses, glass material needs to be changed to synthetic fused silica as custom-made item.

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Excimer Laser Focusing Lenses | ETL/EDL/NEDL

RoHS

Catalog Code W3082

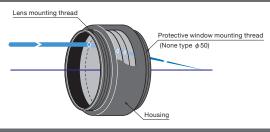
These lenses are manufactured with a synthetic fused silica material and it has a high transmittance value in the ultra-violet wavelength of 180 - 400nm. They have excellent performance and are ideal for focusing and imaging applications. There is no adhesive or heat absorption material used to produce these lenses, as a result they show high resistance to the ultraviolet light.

• They are made of 2 or 3 spherical lenses and they offer correction on spherical and comatic aberration. • Standard focal lengths for Excimer laser with 248nm, 266nm and 355nm.

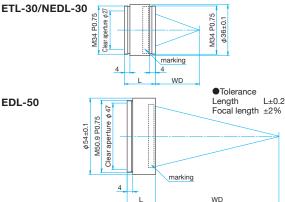
- NA 0.1 or below (ETL model NA 0.25) can be focused to the diffraction limit.







Outline Drawing



Material	Synthetic fused silica for Excimer Laser			
Vaterial of frame	Aluminum Finishing: Black anodized			
Design wavelength	248nm			
Coating	Uncoated			
cceptance angle	±1°			

Guide

- Products that are not listed in the table or in the catalog such as high pulse lasers or different wavelengths are available upon request, please contact our Sales Division.
- Protective Windows is sold separately. Reference B183
- For detail on focal length of each wavelength, please see our web site. WEB Reference Catalog Code W3082

Attention

- These focusing lenses are made for use to image an object located in an infinitive distance or using a point of source as a parallel light.
- The correct direction to input a parallel light is the side with barrel lettering. If the direction is wrong, the spherical aberration will be increased and the image unfocused.
- If Focusing lens is used with the designed wavelength the spherical aberration and transmission will be poor.
- Usage with high power laser or near a high temperature light source, the high heat build-up in the lens may alter the focal length. To avoid this, heat prevention is required.
- To reduce the focus spot size, ensure that the input beam diameter (1/e²) is reduced to half of the effective diameter of the focus lens.
- These focusing lenses are not chromatic lenses; they are not optically corrected.
- The lenses have 4% of reflectivity per surface; therefore about 20% of loss is expected in transmission.

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fe Lenses

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Part Number	Focal length f [mm]	Length L [mm]	Numerical aperture (NA)	Working distance (WD) [mm]
ETL-30-40P	39.6	22	0.34	31.1
ETL-30-50P	49.8	22	0.27	41.6
ETL-30-60P	59.7	22	0.23	52.4
ETL-30-80P	79.8	22	0.17	73.2
NEDL-30-100P	99.9	12	0.14	94.6
NEDL-30-150P	149.3	12	0.09	144.6
NEDL-30-200P	199.3	12	0.07	194.7
EDL-50-100P	100.4	20	0.24	87.1
EDL-50-150P	149.6	20	0.16	137.9
EDL-50-200P	199.1	20	0.12	187.8
EDL-50-250P	249.0	20	0.09	238.0
EDL-50-300P	298.6	20	0.08	288.0

Compatible Optic Mounts

LHF-M34-30, LHF-M50.9-50

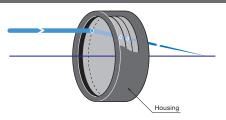


These lenses contain elements which have different refractive indexes and produce a high degree of correction across a bandwidth of 200 - 400nm. They can be used as a laser focusing lens for broadband ultra-violet sources.

- NA 0.1 or below (ETL model NA 0.25) can be focused to the diffraction limit.
- No adhesive or heat absorption materials are used to produce these lenses and they show high resistance to ultra-violet light.
- These are not achromatic corrective but offers correction on spherical and comatic aberration.



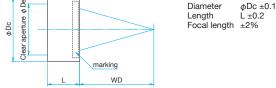
Schematic





Specification

Tolerance



Specifications	
Material	Synthetic fused silica for Excimer Laser – Calcium fluoride (CaF2)
Material of frame	Aluminum Finishing: Black anodized
Design wavelength	200nm, 308nm, 400nm
Coating	Uncoated
Acceptance angle	±1°

Guide

- Products that are not listed in the table or in the catalog such as high pulse lasers or different wavelengths are available upon request,
- We can provide catalog and custom lenses in large volume to your
- For details on focal length of each wavelength, please see details on

- The correct direction to input a parallel light is the side with barrel
- If Focusing lens is used with the designed wavelength the spherical
- Usage with high power laser or near a high temperature light source, the high heat build-up in the lens may alter the focal length. To avoid
- To reduce the focus spot size, ensure that the input beam diameter
- These focusing lenses are not chromatic lenses; they are not optically corrected.
- The lenses have 3 to 4% of reflectivity per surface; therefore about

Part Number	Focal length f [mm]	Diameter	Clear aperture øDe [mm]	Length L [mm]	Numerical aperture (NA)	Working distance (WD) [mm]
UDL-30-50P	50.4	φ34	φ27	17	0.27	39.3
UDL-30-80P	80.0	φ34	φ27	14	0.17	72.4
UDL-30-100P	100.1	<i>φ</i> 34	φ27	13	0.14	92.5
NUDL-30-150P	151.5	<i>\$</i> 34	φ27	16	0.09	137.1
NUDL-30-200P	200.3	<i>φ</i> 34	φ27	16	0.07	185.2
UDL-40-80P	80.3	φ44	φ37	17	0.23	70.1
NUDL-40-100P	100.0	φ44	φ37	18	0.19	87.7
NUDL-40-150P	149.0	φ44	φ37	18	0.12	134.4
NUDL-40-200P	201.2	φ44	φ37	18	0.09	185.5
NUDL-40-250P	249.7	φ44	φ37	19	0.07	230.7
UDL-50-100P	100.8	φ54	φ47	20	0.24	89.1
NUDL-50-150P	149.7	φ54	φ47	21	0.16	136.3
NUDL-50-200P	200.0	φ54	φ47	22	0.12	179.9
NUDL-50-250P	252.4	φ54	φ47	21	0.09	233.0
NUDL-50-300P	300.9	φ54	φ47	22	0.08	278.8

Compatible Optic Mounts

LHF-UDL-30 / -40 / -50

- please contact our Sales Division.
- specifications.
- our web site. WEB Reference Catalog Code W3083

Attention

- These focusing lenses are made for use to image an object located in an infinitive distance or using a point of source as a parallel light.
- lettering. If the direction is wrong, the spherical aberration will be increased and the image unfocused.
- aberration and transmission will be poor.
- this, heat prevention is required.
- (1/e²) is reduced to half of the effective diameter of the focus lens.
- 13% of loss is expected in transmission.

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fθ Lenses

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Guide

F-Theta Lenses are used for laser marking, bar code reader, laser micromachining and other laser

• F-Theta lenses convert a rotational movement of a galvanometer mirror into a linear motion on the focal plane by using

Telecentric type is also available that can be irradiated vertically to the focusing plane.

• Also available for fundamental YAG laser (1064nm), harmonic lasers (266nm, 355nm, 532nm).

▶ Transmittance value is a representative value only and is not guaranteed. If you have any questions, please feel free to contact our Sales Division.

RoHS

- We accept orders to suit customized requirements.
- We also fabricate laser scanning systems which combine the galvanometer mirror and fθ lens as a unit.

Attention

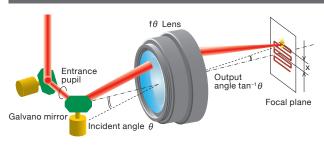
- We do not recommend using fθ lens in an imaging system because it is designed for a scanning type optical system.
- Please position the incident pupil of the fθ lens beam into the scanning system (galvanometer mirror). If the incident pupil is not in position of the beam scanning system, the optimum focusing spot cannot be achieved because of increased aberration.

f $ heta$ Lenses dimension table											
Part Number	A (mm)	B (mm)	C (mm)	D (mm)	E (mm)	F (mm)	φG (mm)	φH (mm)	I	φJ (mm)	K (mm)
fθ-100-266T	60	57.8	43	5	6	6	φ97	φ82g6	M80 P1	φ69	74.8
fθ-150-266T	80	73.3	65	3	6	6	φ122	φ102g6	M100 P1	φ89	88.3
f ∂-100-355 T	60	56.3	42	6	6	6	φ97	φ82g6	M80 P1	<i>φ</i> 69	74.3
fθ-100-355THG	80	109.6	59	9	6	6	φ112	φ102g6	M100 P1	φ84	130.6
fθ-150-355T	80	72.3	64	4	6	6	φ122	φ102g6	M100 P1	φ89	88.3
fθ-100-532T	60	51.5	50	-	6	4	φ92	φ82g6	M80 P1	_	61.5
fθ-300-1064	39	35.9	27.3	3.7	8	-	<i>φ</i> 91	-	M80 P1	φ76	47.6
fθ-100-1064T	60	49.5	47.5	_	6.5	6	φ92	φ82g6	M80 P1	_	62

f d Lenses Design wavelength Focal length Entrance pupil Working distance Transmittance Scanning angle Scanning Range Part Number Telecentric (Angle of Incidence: 0°) diameter (WD) [°] [mm] [nm] [mm] [mm] [mm] [%] fθ-100-266T 100.4 135.9 266 φ12 ±15 φ52 93 fθ-150-266T 266 149.9 φ12 ±15 φ78 205.1 93 fθ-100-355T 355 99.85 φ12 ±15 φ52 136.1 93 0 fθ-100-355THG 355 100.1 φ14 ±15 φ52 60.94 90 0 f@-150-355T 355 150.2 φ12 ±15 φ78 207.2 93 fθ-100-532T 532 100.3 φ12 ±15 φ52 121.1 90 fθ-300-1064 1064 299.8 φ16 ±23 φ240 361.6 95 0 fθ-100-1064T 1064 100.3 φ12 ±15 φ52 123.1 95







By using the f theta lens, it is possible to be moved a laser light spot in constant speed linear motion on the focal plane by scanning the mirrors such as galvanometer scanner mirrors.

The f theta lens enables this by the effect of distortion.

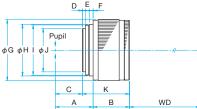
Mathmatically it is expressed as following; focal length = "f", ideal image height = "y", the angle of scanned = " θ " therefore, $y = f\theta$.

In the normal single lens, the ideal image height "y" is represented by

"y = f tan θ ". Characteristics of both are the same in a small angle range. However, the difference is greater angle increases.

Outline Drawing

fθ Lenses D



f θ Lenses for YAG (f θ -L/f θ -B/f θ -270-1064) Diamond knurling Screw Pupil φGφH φF φI đΚ С D Е В WD A

f θ Lenses for YAG dimension table Α B С D F φF φG φH φI .1 φK Part Number Screw (mm) fθ-100-532L 53.3 17.8 22.5 22.8 8 48.6 φ83 M85 P1 φ89 φ80 φ72 φ60 fθ-100-1064L 53.3 17 20 M85 P1 25.3 8 φ87 φ80 φ69 φ57 50.3 φ83 fθ-150-1064B 63 19.8 28 56 M85 P1 26.8 8.2 φ87 φ80 φ74.5 φ64 φ86 fθ-220-1064L 59.8 8 M85 P1 21.1 32.1 19.7 φ97 φ80 φ68 48.8 φ97 fθ-270-1064 59.7 M85 P1 33.5 26.0 24.7 9 φ106 φ74 φ64 67.2 φ106

fe Lenses for YAG Entrance pupil Scanning angle Scanning Range Working distance (WD) Transmittance Design Focal length Part Number wavelength Telecentric [°] [mm] [%] [nm] [mm] [mm] [mm] fθ-100-532L 100.2 532 φ12 +22.9 φ80 114.7 >95 fθ-100-1064L 1064 99.93 φ12 ±22.9 φ80 109.6 >95 fθ-150-1064B 152.1 1064 φ15 ±24.0 φ127.4 168.6 >95 fθ-220-1064L 1064 220.0 φ12 ±24.0 φ184 254.2 >95 fθ-270-1064 1064 273.0 φ15 ±24.13 φ230 318.9 >95

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This objective lens can be used for laser machining using pulsed laser of SHG (532nm), THG (355nm), and FHG (266nm) YAG laser. Objective lense provides high transmittance at three harmonic wavelengths of YAG.

- With its long working distance and corrected field curvature, its natural observation image is obtained to the periphery of viewing the field.
- It is the long working infinity correction function that is used to introduce a laser system and coaxial observation.
- It allows observation of the sample with visible light (400 500nm).
- Laser Damage Threshold (Typical) 0.09 J/cm² (266nm), 0.1J/cm² (355nm), 0.2J/cm² (532nm)
 - (Laser pulse width 10ns, repetition frequency 20Hz)



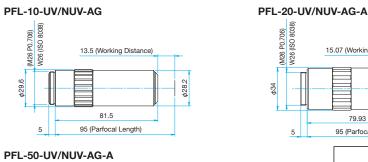
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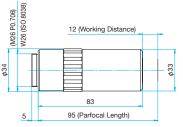
- Available fixed objective lens holder (LHO-26).
- WEB Reference Catalog Code W4024
- When the objective lens is fixed to a 2 axis holder, please consult our Sales Division.
- For laser processing, we offer a dichoric block (DIMC) and for laser unit with coaxial illumination and observation (OUCI-2). WEB Reference Catalog Code W2041

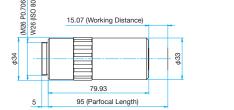
Attention

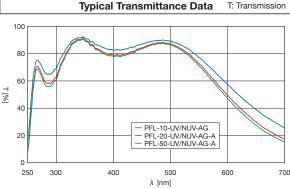
- When an objective lens is used in laser processing, use the diameter of the incident beam to extend to a size of half the pupil diameter (1/e2). A small light spot cannot be achieved when the incident beam is too narrow. Please note if there is a laser energy density increase, there will be a high possibility of damage to the objective lens.
- The surface of an objective lens can be contaminated by debris during processing. To avoid this, please have sufficient working distance (WD) and insert a thin protective glass on the objective.
- Magnification is the value when using the imaging lens f=200mm. When used in a microscope lens barrel from other manufacturers there may be different magnifications. The actual magnification should be calculated from the ratio of the focal length of the objective lens and the focal length of the imaging lens to verify the focal length of the imaging lens barrel to be used.

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Specifications										
Part Number	Item name	Magnifi- cation	Focal length f [mm]	Numerical aperture NA	Working distance WD [mm]	Resolution (λ=550nm) [μm]	Focal depth (λ=550nm) [μm]	Real fi (Eyepiece φ24mm) [mm]	ield of view (Imaging device 1/2-inch) [mm]	Weight [kg]
PFL-10-UV/NUV-AG	MPlan UV/NUV 10x	10x	20	0.20	13.5	1.40	±6.9	φ2.4	0.48×0.64	0.30
PFL-20-UV/NUV-AG-A	MPlan UV/NUV 20x	20x	10	0.36	15.07	0.76	±2.1	φ1.2	0.24×0.32	0.35
PFL-50-UV/NUV-AG-A	MPlan UV/NUV 50x	50x	4	0.42	12.0	0.65	±1.6	φ0.48	0.10×0.13	0.41
Compatible Optic Mounts	•									

I HO-26



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Ultra-violet Objective Lenses | PFL-UV-AG



This objective lens can be used for laser machining using pulsed laser of SHG (532nm) YAG laser and FHG (266nm) YAG. Chromatic aberration is suppressed in both the visible and UV laser wavelength, achieving a high transmittance.

- With its long working distance and field curvature corrected, its natural observation image is obtained to the periphery of the visual field.
- It is the long working infinity correction function that is used to introduce a laser system and coaxial observation.
- It is also used for the observation of ultra-violet light.

10×10

• Laser Damage Threshold (Typical) 0.09 J/cm² (266nm), 0.2J/cm² (532nm)

WX09

(Laser pulse width 10ns, repetition frequency 20Hz)

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					200	300		500 6 \[nm]	00 700	800
Specifications										
Part Number	Item name	Magnifi- cation	Focal length f [mm]	Numerical aperture NA	Working distance WD [mm]	Resolution (λ=550nm) [μm]	Focal depth (λ=550nm) [μm]	Real f (Eyepiece ¢24mm) [mm]	ield of view (Imaging device 1/2-inch) [mm]	Weight [kg]
PFL-10-UV-AG	MPlan UV 10x	10x	20	0.20	13.5	1.4	±6.9	φ2.4	0.48×0.64	0.30
PFL-20-UV-AG-A	MPlan UV 20x	20x	10	0.36	15.07	0.76	±2.1	φ1.2	0.24×0.32	0.35
PFL-50-UV-AG-A	MPlan UV 50x	50x	4	0.42	12.0	0.65	±1.6	φ0.48	0.10×0.13	0.41
PFL-80-UV-AG-LC00	MPlan UV 80x	80x	2.5	0.55	10.0	0.50	±0.9	φ0.30	0.06×0.18	0.35

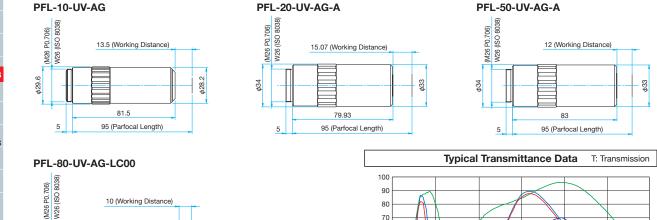
Compatible Optic Mounts

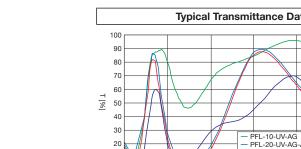


Guide

- Available fixed objective lens holder (LHO-26). WEB Reference Catalog Code W4024
- When the objective lens is fixed to a 2 axis holder, please consult our Sales Division.
- For laser processing, we offer a dichoric block (DIMC) and for laser unit with coaxial illumination and observation (OUCI-2). WEB Reference Catalog Code W2041
- When an objective lens is used in laser processing, use the diameter of the incident beam to extend to a size of half the pupil diameter (1/e2). A small light spot cannot be achieved when the incident beam is too narrow. Please note if there is a laser energy density increase, there will be a high possibility of damage to the objective lens. The surface of an objective lens can be contaminated by debris
- during processing. To avoid this, please have sufficient working distance (WD) and insert a thin protective glass on the objective.
- Magnification is the value when using the imaging lens f=200mm. When used in a microscope lens barrel from other manufacturers there may be different magnifications. The actual magnification should be calculated from the ratio of the focal length of the objective lens and the focal length of the imaging lens to verify the focal length of the imaging lens barrel to be used.

Outline Drawing





I HO-26

This objective lens can be used for laser machining using pulsed laser of THG (355nm) YAG laser. Chromatic aberration is suppressed in both the visible and UV laser wavelength, achieving a high transmittance.

- With its long working distance and field curvature corrected, its natural observation image is obtained to the periphery of the visual field.
- With its long working infinity correction function; this objective lens can be used for a laser system and coaxial observation. • It is also used for the observation of near ultra-violet light.
- This objective lens can be used with a pulse laser of visible light (532nm). • Laser Damage Threshold (Typical) 0.05J/cm² (355nm), 0.1J/cm² (532nm)
 - (Laser pulse width 10ns, repetition frequency 20Hz)

X09 dA nery VU

Guide

- Available fixed objective lens holder (LHO-26). WEB Reference Catalog Code W4024 When the objective lens is fixed to a 2 axis holder, please consult our Sales Division.
 - For laser processing, we offer a dichoric block (DIMC) and for laser unit
 - with coaxial illumination and observation (OUCI-2). ce Catalog Code W2041

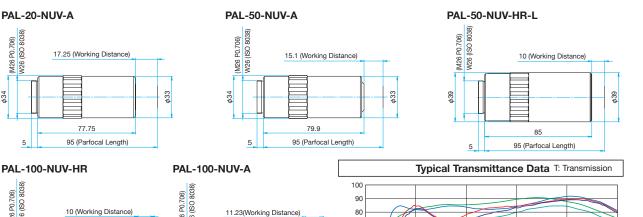
RoHS

Catalog W3458

Attention

- When an objective lens is used in laser processing, use the diameter of the incident beam to extend to a size of half the pupil diameter $(1/e^2)$. A small light spot cannot be achieved when the incident beam is too narrow. Please note if there is a laser energy density increase, there will be a high possibility of damage to the objective lens.
- The surface of an objective lens can be contaminated by debris during processing. To avoid this, please have sufficient working
- distance (WD) and insert a thin protective glass on the objective.
 Magnification is the value when using the imaging lens f=200mm. When used in a microscope lens barrel from other manufacturers there may be different magnifications. The actual magnification should be calculated from the ratio of the focal length of the objective lens and the focal length of the imaging lens to verify the focal length of the imaging lens barrel to be used.

Outline Drawing



70 60

40

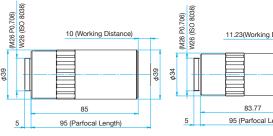
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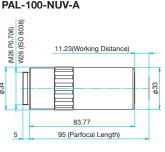
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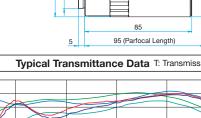
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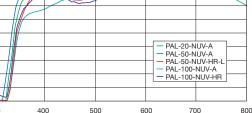
0 300

T [%] 50









λ [nm]

Part Number	Item name	Magnifi- cation	Focal length f	Numerical aperture NA	Working distance WD	Resolution (λ=550nm) [μm]	Focal depth (λ=550nm) [μm]	(Eyepiece φ24mm)	ield of view (Imaging device 1/2-inch)	Weight [kg]
PAL-20-NUV-A	MPlanApo NUV 20x	20x	[mm] 10	0.40	[mm] 17.25	0.69	±1.7	[mm] φ1.2	[mm] 0.24×0.32	0.35
PAL-50-NUV-A	MPlanApo NUV 50x	50x	4	0.45	15.1	0.61	±1.4	φ0.48	0.10×0.13	0.36
PAL-50-NUV-HR-L	MPlanApo NUV HR 50x	50x	4	0.65	10.0	0.42	±0.65	φ0.48	0.10×0.13	0.51
PAL-100-NUV-A	MPlanApo NUV 100x	100x	2	0.57	11.23	0.48	±0.8	φ0.24	0.05×0.06	0.38
PAL-100-NUV-HR	MPlanApo NUV HR 100x	100x	2	0.70	10.0	0.39	±0.6	φ0.24	0.05×0.06	0.53

I HO-26

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Expanders Others This is a high NA infinity corrected objective lens for laser processing (femtosecond laser and fundamental of YAG laser). You can also observe the laser beam coaxially with a laser processed

surface that is designed to reduce the aberration of the visible wavelength.

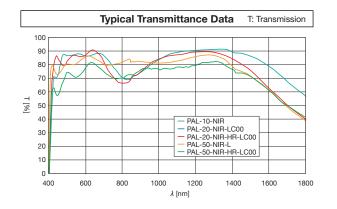
• With its long working distance and field curvature corrected, its natural observation image is obtained to the periphery of the visual field.

- It is the long working infinity correction function that is used to introduce a laser system and coaxial observation.
- It is also used for the observation of infrared light.

Infrared (NIR) Objective Lenses

- PAL-20-NIR-LC00/PAL-20-NIR-HR-LC00/PAL-50-NIR-HR-LC00 include protective glass unit (t=1.8mm). The protective glass will help protect the objective lens from debris spattering and scattered by laser processing. The protective glass unit can be replaced.
- These variety of objective lens can be used with a pulse laser of visible light such as 532nm. The damage threshold of each lens is 0.1J/cm² at 532nm, 0.2J/cm² at 1064nm (reference). (Laser pulse width 10nSec, repetition frequency 20Hz)





Guide

PAL-NIR

- Available fixed objective lens holder (LHO-26).
- When the objective lens is fixed to a 2 axis holder, please consult our Sales Division.
- For laser processing, we offer a dichoric block (DIMC) and for laser unit with coaxial illumination and observation (OUCI-2).

 WEB Reference
 Catalog Code

 WEB Reference
 Catalog Code

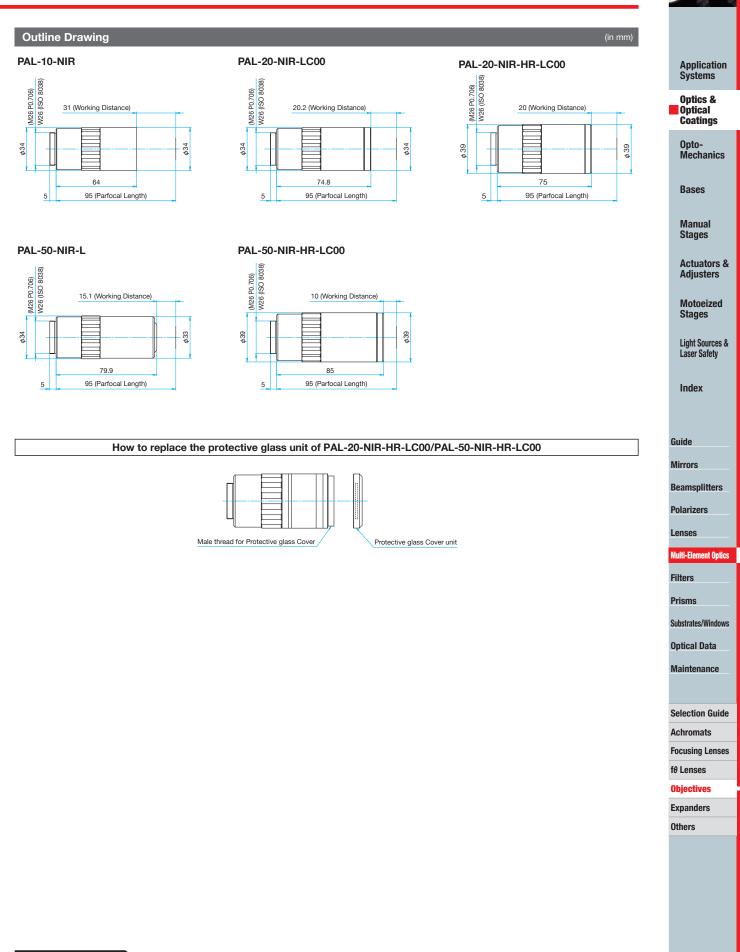
Attention

- When an objective lens is used in laser processing, use the diameter of the incident beam to extend to a size of half the pupil diameter (1/e²). A small light spot cannot be achieved when the incident beam is too narrow. Please note if there is a laser energy density increase, there will be a high possibility of damage to the objective lens.
- The surface of an objective lens can be contaminated by debris during processing. To avoid this, please have sufficient working distance (WD) and insert a thin protective glass on the objective.
- If the incident laser beam femtosecond is below 100fs, there is a possibility that the pulse width will spread.
- Magnification is the value when using the imaging lens f=200mm. When used in a microscope lens barrel from other manufacturers there may be different magnifications. The actual magnification should be calculated from the ratio of the focal length of the objective lens and the focal length of the imaging lens to verify the focal length of the imaging lens barrel to be used.
- PAL-20-NIR-HR-LC00/PAL-50-NIR-HR-LC00 is designed in consideration of the thickness of including protective glass. If user removes the protective glass, the objective will not meet the performance specifications noted.

Specifications										
Part Number	Item name	Magnifi- cation	Focal length f [mm]	Numerical aperture NA	Working distance WD [mm]	Resolution (λ=550nm) [μm]	Focal depth (λ=550nm) [μm]	Real f (Eyepiece φ24mm) [mm]	ield of view (Imaging device 1/2-inch) [mm]	Weight [kg]
PAL-10-NIR	MPlanApo NIR 10x	10x	20	0.30	31.0	0.92	±3.1	φ2.4	0.48×0.64	0.30
PAL-20-NIR-LC00	MPlanApo NIR 20x	20x	10	0.40	20.2	0.69	±1.7	φ1.2	0.24×0.32	0.36
PAL-20-NIR-HR-LC00	MPlanApo NIR HR 20x	20x	10	0.45	20.0	0.61	±1.4	φ1.2	0.24×0.32	0.42
PAL-50-NIR-L	MPlanApo NIR 50x	50x	4	0.45	15.1	0.61	±1.4	φ0.48	0.10×0.13	0.34
PAL-50-NIR-HR-LC00	MPlanApo NIR HR 50x	50x	4	0.67	10.0	0.41	±0.61	φ0.48	0.10×0.13	0.48



6



Compatible Optic Mounts

LHO-26



Optics & Optical

. Coatings

Opto-

Long Working Distance Objective Lenses | EPL/EPLE

With its long working infinity correction function; this objective lens can be used for a laser system and coaxial observation.

The objective will allow user to focus a visible laser or microscopic observation of objects from a distance.

- Chromatic aberration is corrected in the visible range (400 700nm).
- Two types of parfocal distance are available, 45mm and 90mm.
- This parfocal 95mm lens has a long working distance and a corrected field curvature. Its natural observation image is obtained to the periphery of the visual field.
- It is possible to improve the response speed in the driving mechanism of the 45mm parfocal objective lens (SFS-OBL/ SFAI-OBL); with a lightweight auto focusing solution.

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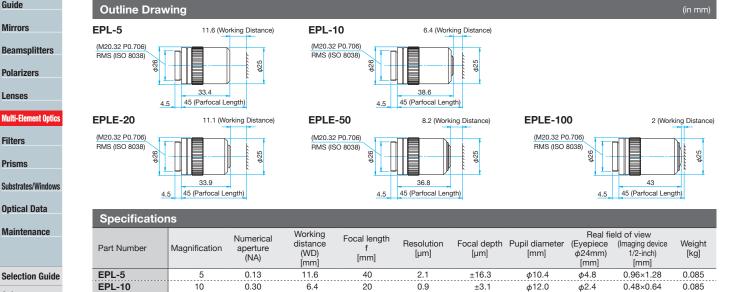
Guide

Available fixed objective lens holder (LHO-20.32).

- ce Catalog Code W4024 WEB Ref
- When the objective lens is fixed to a 2 axis holder, please consult our Sales Division. For laser processing, we offer a dichoric block (DIMC) and for laser
- unit with coaxial illumination and observation (OUCI-2). ce Catalog Code W2041

Attention

- When an objective lens is used in laser processing, use the diameter of the incident beam to extend to a size of half the pupil diameter (1/e2). A small light spot cannot be achieved when the incident beam is too narrow Please note if there is a laser energy density increase, there will be a high possibility of damage to the objective lens.
- The surface of an objective lens can be contaminated by debris during processing. To avoid this, please have sufficient working distance (WD) and insert a thin protective glass on the objective.
- Magnification is the value when using the imaging lens f=200mm. When used in a microscope lens barrel from other manufacturers there may be different magnifications. The actual magnification should be calculated from the ratio of the focal length of the objective lens and the focal length of the imaging lens to verify the focal length of the imaging lens barrel to be used.

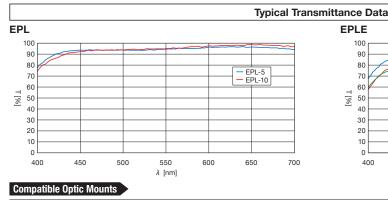


Achromats Focusing Lenses

fe Lenses

Objectives

Expanders Others



0.40

0.55

0.80

11.1

8.2

2.0

10

4

2

0.7

0.5

0.3

EPLE

100

90

80

70

60

50 [%]

40

30

20

10

0

400

450

±1.7

±0.9

±0.4

φ8.0

φ4.4

φ3.2

500

550

λ [nm]

600

φ1.2

φ0.48

φ0.24

0.24×0.32

0.10×0.13

0.05×0.06

0.085

0.095

0.105

T: Transmission

- EPLE-20 - EPLE-50 - EPLE-100

650

700

20

50

100



EPLE-20

EPLE-50

EPLE-100

The long working distance objective lens infinity correction function and par focal length 95mm can be used for a laser system and coaxial observation. The objective will allow user to focus a visible laser or microscopic observation of objects from a distance.

- Chromatic aberration is corrected in the visible range (400 700nm).
- PAL/PAL-L has a long working distance and a corrected field curvature. Its natural observation image is obtained to the periphery of the visual field.

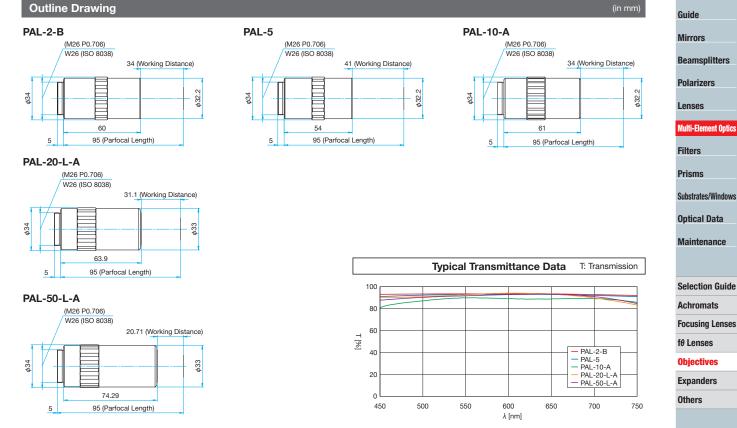


Guide

- Available fixed objective lens holder (LHO-26).
- WEB Reference Catalog Code W4024
- When the objective lens is fixed to a 2 axis holder, please consult our Sales Division.
- For laser processing, we offer a dichoric block (DIMC) and for laser unit with coaxial illumination and observation (OUCI-2).
 WEB Reference Catalog Code W2041

Attention

- When an objective lens is used in laser processing, use the diameter of the incident beam to extend to a size of half the pupil diameter (1/e²). A small light spot cannot be achieved when the incident beam is too narrow. Please note if there is a laser energy density increase, there will be a high possibility of damage to the objective lens.
- The surface of an objective lens can be contaminated by debris during processing. To avoid this, please have sufficient working distance (WD) and insert a thin protective glass on the objective.
- Magnification is the value when using the imaging lens f=200mm. When used in a microscope lens barrel from other manufacturers there may be different magnifications. The actual magnification should be calculated from the ratio of the focal length of the objective lens and the focal length of the imaging lens to verify the focal length of the imaging lens barrel to be used.



Specifications										
Part Number	Item name	Magnifi- cation	Focal length f [mm]	Numerical aperture NA	Working distance WD [mm]	Resolution (λ=550nm) [μm]	Focal depth (λ=550nm) [μm]	Real f (Eyepiece φ24mm) [mm]	ield of view (Imaging device 1/2-inch) [mm]	Weight [kg]
PAL-2-B	MPlanApo 2x	2x	100	0.055	34.0	5	91	φ12	2.4×3.2	0.25
PAL-5	MPlanApo 5x	5x	40	0.14	41.0	2	14	φ4.8	0.96×1.28	0.24
PAL-10-A	MPlanApo 10x	10x	20	0.3	34.0	0.92	3.1	φ2.4	0.48×0.64	0.24
PAL-20-L-A	MPlanApo SL20x	20x	10	0.3	31.1	0.92	3.1	φ1.2	0.24×0.32	0.28
PAL-50-L-A	MPlanApo SL50x	50x	4	0.42	20.7	0.65	1.6	φ0.48	0.10×0.13	0.31

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• These objective lenses are finite.

Microscope Objectives

OBL



These objectives are educational microscope objectives. They are to the JIS standard (Japanese Industry Standard), have Short focal length, high NA and are fit for beam divergent use.

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• Full color correction throughout the visible wavelength.

• To mount it to a microscope, a finite 160mm adaptor is required.

• The OBL-40 and OBL-60 have a built-in spring in the tip of the objective lens.

• The distance from the attachment face of the objective lens to the image is 150mm.

Guide

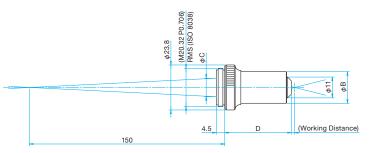
- ► Use a special filter (SFB) to correct the wave front distortion. WEB Reference Catalog Code W4036
- Objective holder (LHO) is available for these objective lenses.
 WEB Reference Gatalog Code W4024
- Cross holder (TAT) is now available.

Attention

- Do not use objectives with high power laser.
- The objective lenses are finite and are not to be used with infinite lens barrel or poor images will result.
- ▶ To be used only in the visible wavelength range.

Outline Drawing

(in mm



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Focusing Lenses

fe Lenses

Objectives

Expanders Others

Specification	s							
Part Number	Magnification	Length D [mm]	Barrel diameter ∳B [mm]	Pupil diameter φC [mm]	Focal length f [mm]	NA	Working distance (WD) [mm]	Weight [kg]
OBL-10	10	30.5	φ16.7	φ8.3	16.6	0.25	5.5	0.05
OBL-20	20	35.2	φ16.7	φ7.1	9.0	0.40	1.7	0.05
OBL-40	40	36.4	φ19.7	φ5.8	4.5	0.65	0.6	0.06
OBL-60	60	36.7	φ19.7	φ4.9	2.91	0.85	0.3	0.07

Compatible Optic Mounts

LHO-20.32, -20.32A / TAT-18OA + TAT16RO



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These reflective Microscope objective lenses are optimized for chromatic aberration over a bandwidth of 350nm to 7um. They are mainly used in microscope-spectrometry and failure analysis in the semiconductor industry.

- Adjustable for use with various types of microscope tubes with focal length ranging from 80mm to infinite
- The reflection mirror is strengthened with aluminium coating and MgF₂ protective layer.
- The RMS(M20.32 P0.706) mounting thread conforms to JIS standard and is compatible with all major microscope tubes. • The focus point and image size of visible, UV and IR wavelengths shows no difference and precise matching of the images is possible.



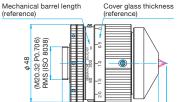
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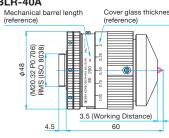
- There is no protective layer in aluminium coating for the vacuum ultra-violet spectrum and gold layer coating for near infrared is available as an option.
- An adapter for the objective lens turret is available (OBRLR-AMT). Check with our International Sales Division or your microscope manufacturer for compatibility and the use of reflective microscope objective lenses.
- Specific holder for microscope objective lenses (LHO-20.32) is available. WEB Reference Catalog Code W4024

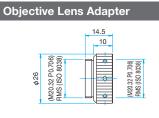
Attention

- These objectives are not to be used for laser processing due to light axis shielding of the reflective mirror.
- There are microscopes that cannot be used with a turret.
- The cover glass is not mobile. Use the adjustable correction collar to adjust the focal length and the cover glass thickness.
- The center reflective mirror shields the center of the light axis. For direct light experiments, a low intense light in the center is expected.
- The light intensity loss if expected to be around 45%. (The center mirror shielding 36% and the aluminum reflectivity 90%)

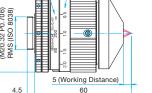
Outline Drawing OBLR-10A OBLR-20A Mechanical bar (reference) Cover glass thickness (reference) Cover glass thickness Mechanical barrel length (reference) 706) 8038 (M20.32 P0.7 RMS (ISO 80 φ26 706) 206) (M20.32 P0.7 RMS (ISO 80 .32 PO. φ48 φ48 S (M20.3 Part Number 7 (Working Distanc 16 (Working Distance 4.5 75 4.5 60 **OBLR-30A** OB







OBLR-AMT



BLR-40A Mechanical barre (reference)	el le	ength Cover glass thickness (reference)
φ48 (M20.32 P0.706) RMS (ISO 8038)		
		3.5 (Working Distance)

Objectives Expanders

fe Lenses

Others

Specification	S							
Part Number	Magnification	Wavelength Range	Focal length f [mm]	Numerical aperture (NA)	Field of view [mm]	Working distance (WD) [mm]	Mechanical tube length [mm]	Shielding ratio [%]
OBLR-10A	10	350nm – 7µm	19.9	0.2	φ1.0	16	80 – ∞ (Variable)	about 36
OBLR-20A	20	350nm – 7µm	10.0	0.35	φ0.5	7	80 – ∞ (Variable)	about 36
OBLR-30A	30	350nm – 7µm	6.7	0.41	φ0.34	5	$80 - \infty$ (Variable)	about 36
OBLR-40A	40	350nm – 7µm	5.0	0.49	φ0.25	3.5	80 – ∞ (Variable)	about 36

Compatible Optic Mounts

I HO-20.32



Glass Thickness Corrected Objective Lenses Others

You can check our WEB catalog for the objective lenses that are not listed in the catalog.

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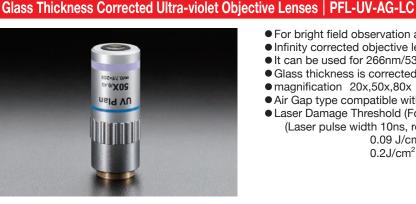
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Expanders Others



For bright field observation and laser processing

- Infinity corrected objective lens It can be used for 266nm/532nm.
- Glass thickness is corrected to t=0.7mm or 1.1mm.
- magnification 20x,50x,80x
- Air Gap type compatible with high-energy
- Laser Damage Threshold (For reference only)
 - (Laser pulse width 10ns, repetition frequency 20Hz) 0.09 J/cm² (266nm) 0.2J/cm² (532nm)

Glass Thickness Corrected Near Ultra-violet Objective Lenses | PAL-NUV-LC

Catalog W4364

Catalog W3463



- For bright field observation and laser processing
- Infinity corrected objective lens
- It can be used for 355nm
- Glass thickness is corrected to t=0.7mm or 1.1mm.
- magnification 20x,50x,100x
- With Plan-Apochromat
- Laser Damage Threshold (For reference only) (Laser pulse width 10ns, repetition frequency 20Hz) 0.05 J/cm² (355nm) 0.1 J/cm² (532nm)

Glass Thickness Corrected Infrared Objective Lenses | PAL-NIR-LC

oqA nsI9 Alv 50X,0.57

Catalog W4365

- For bright field observation and laser processing Infinity corrected objective lens
 - It can be used for 1064nm
 - Glass thickness is corrected to t=0.7mm or 1.1mm.
 - Magnification 20x,50x
 - Laser Damage Threshold (For reference only) (Laser pulse width 10ns, repetition frequency 20Hz) 0.1 J/cm² (532nm)

0.2 J/cm² (1064 nm)

Glass Thickness Corrected Infrared Objective Lenses | PAL-NIR (780)





- Infinity corrected objective lens
- It can be used for 780nm
- Glass thickness is corrected to t=0.7mm
- Magnification 20x,50x
- Laser Damage Threshold (For reference only) (Laser pulse width 10ns, repetition frequency 20Hz) 0.1 J/cm² (532nm) 0.15 J/cm² (780nm)

mm,

W

J

S Hz

Requirement

Requirement

Country/Address Name & Designation Estimate Drawing Number Yes: by Date Desired Budget **Delivery Date** Intention Please fill in as concrete as possible. Design wavelength Focal length Acceptance angle Magnification NA Distortion Telecentric \Box YES(θ < °) □ NO **Object - Image Distance** Working distance W.D. Flange back Spot Size (1/e²) Resolution Real field of View mm, ((Imaging device)

Contact sheet

To: Sigma Koki Co., Ltd.

Contact sheet for Custom-made Objective Lenses

FAX

Estimation

Date

FAX +81-3-5638-6550

E-mail

Name

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	Optics & Optical Coatings	
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Catalog W3820

Order

(Tentative name is okay

nm

mm 0

mm

mm

mm

μm

μm

inch)

mm

mm

mm

General Catalog

Pitch

🗌 No

JP Yen

Affiliation Organization Name) Department

TEL

Mounting screw thread

Adjustable diaphragm Coaxial illumination

> Divergence angle Beam size

 M^2

Power

Pulse width

Repetition frequency

or Energy

External dimensions

Specifications of Light

Source Used

Sigma Koki Co., Ltd.

Not requirement

Not requirement



Optics &

• The optical system of the beam expander utilizes an air gap configuration that does not use an adhesive bonding of lens. • By turning the diopter ring that is attached to the center of the beam expander, you can make variable beams such as a focused beam, collimated beam, and a divergent beam. It is used when you want to vary the position of the beam waist

The lens design takes into account the wavefront aberration, so it can be used in an optical system

BEHP



High Power Laser Beam Expander

These laser beam expanders are designed for use with a high-power laser. Fine adjustment of the collimator is available with the diopter correction function.

with high precision, such as a laser interferometer or laser processing.

Specifications	
Lens Material	Synthetic fused silica
Configuration of lens	2 group 4plates Galilean
Acceptance range of incident angle	±1°
Coating	Antireflection coating (Design wavelength: 633nm)
A range of the length of lens barrel	±5mm

RoHS

Catalog Code W3200

Guide

- We also can provide a holder for our laser beam expander (KLH-BE) for the fine adjustment with tilt angle and to secure the beam expander. WEB Reference Catalog Code W4147
- It is also available to provide beam expander of wavelength other than products on-line and in our catalog and achromatic in two wavelengths or more.

Attention

It is not possible to create a collimated light obtained by reducing the beam diameter using in the opposite direction a beam expander. In this case, please use the appropriate optical system by determining the position of the beam waist and divergence angle of the laser beam.

Specifications				Primary material: Aluminur Finish: Black Anodized
Part Number	Design wavelength [nm]	Beam magnification	Input Clear aperture [mm]	Laser Damage Threshold* [J/cm ²]
BEHP-3-266	266	3	<i>ф</i> 10	2
BEHP-5-266	266	5	φ6	2
BEHP-10-266	266	10	φ3	2
BEHP-3-355	355	3	<i>ф</i> 10	4
BEHP-5-355	355	5	φ6	4
BEHP-10-355	355	10	φ3	4
BEHP-3-532	532	3	<i>φ</i> 10	5
BEHP-5-532	532	5	φ6	5
BEHP-10-532	532	10	φ3	5
BEHP-3-1064	1064	3	<i>ф</i> 10	7
BEHP-5-1064	1064	5	φ6	7
BEHP-10-1064	1064	10	φ3	7

* Laser pulse width 10ns, repetition frequency 20Hz

Compatible Optic Mounts

KLH-BE-M34H

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and where precision collimation adjustment is necessary.

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Outline Drawing Locking Screw Diopte M34 P= φ48 φ57 φ43 φ60 5 95(±4)

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Focusing Lenses fe Lenses

Objectives Expanders

It is capable of 1x to 3x times changing high-power zoom Laser beam expander.



BEZHP



Fine adjustment of the collimator is available with diopter correction function. It can be used in an optical system with high precision, such as a laser interferometer and processing Application Systems by the lens design that takes into account the wavefront aberration. **Optics &** • The optical design of the beam expander is an air gap configuration that does not use an adhesive to bond the lenses. **Optical** This allows the beam expander to be used with a high-power laser. By the Galileo type lens configuration, it reduces the Coatings number of aberration correction lens, and enables the shorter overall length of the beam expander. • By turning the diopter ring that is attached to the center of the beam expander, you can make variable beams such as Opto-Mechanics the focused beam, collimated beam, and the divergent beam. It is used when you want to vary the position of the beam waist and if strict collimation adjustment is necessary. Bases Guide We provide the laser beam expander holders (KLH-BE) for optical-Manual axis adjustment of the laser beam expander. Stages WEB Reference Catalog Code W4147 We can also provide a beam expander for wavelengths not listed Actuators & on-line or in our catalog, please contact our Sales Division with Adjusters your request. Motoeized Attention Stages It is not possible to create a collimated light obtained by reducing the beam diameter using in the opposite direction a beam expander. Light Sources & In this case, please use the appropriate optical system by determining Laser Safety the position of the beam waist and divergence angle of the laser beam. Index **Outline Drawing** Clamp (Zoom Clamp (Diopter) Guide Zoom rine Diopter ring Mirrors P0.7 **Beamsplitters b**38 φ25 440 M22 F Polarizers 90 - 95 Lenses Multi-Element Optics Filters Prisms Substrates/Windows **Optical Data** Maintenance Selection Guide **Achromats** Focusing Lenses fe Lenses Objectives Expanders Others **Specifications** Laser Damage Threshold* Design Input Variable Weight Part Number wavelength Clear aperture Coating Material magnification [kg] [nm] [mm] [J/cm²] BEZHP-1/3-532 1 – 3 532 5.0 Antireflection coating Synthetic fused silica 0.3 ф5 * Laser pulse width 10ns, repetition frequency 20Hz Compatible Optic Mounts

KLH-BE-M22H



Optics & Optical Coatings

Laser Beam Expanders With diopter correction function

focused beam. A beam waist or an accurate adjustment of the collimation is required.
There is a wide variety with different magnification and wavelengths to choose from.



This is an optical system for expanding a small collimated laser beam to a larger one. Fine adjustment of the collimator is available using the diopter correction function. You can use in a high precision optical system like an interferometer or laser processing with lens designed for wave from aberration.

• The beam expander optical system is air-space with no bonded lenses and can be used for high powered laser applica-

• With the Galilean type lens configuration, it reduces the number of aberration corrections and shortens the length of the

• By turning the diopter ring on the beam expander, you can have a varied collimated beam with beam divergence on the

• With the different types of BE-V and LBED visible lasers, can be attached to a He-Ne (05-LHP) lasers with an adapter

Optics & Optical Coatings

tions.

beam expander.

(included).

Outline Drawing

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- Opto-
- Mechanics
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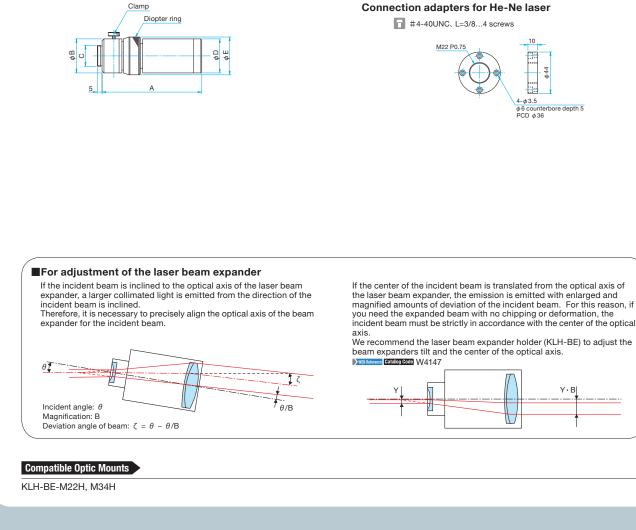
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fe Lenses

Objectives

Expanders





Guide

- We provide the laser beam expander holders (KLH-BE) for opticalaxis adjustment of the laser beam expander.

 WEB Reference
 Catalog Code
- We can also fabricate achromatic beam expanders with multiple wave lengths other than those found in on-line and in our catalog, call our Sales Division for more information.
- Fabrication of beam expander for high-energy pulsed laser is also available. Reterence: B200

Attention

By using in the opposite direction, it will not create a reduceduction in diameter of the collimated beam. Please use the appropriate optical system by determining the position of the beam waist and the divergence angle of the laser beam.

Accessories for visible light (BE-V/LBED)



Specification	ıs								Primary material: / Finish: Black Anor	
Part Number	Design wavelength [nm]	Expansion ratio	Input aperture (MAX) [mm]	Barrel length A [mm]	φB [mm]	Mounting thread C	φD [mm]	Diameter φE [mm]	Laser Damage Threshold* [J/cm ²]	
BE-2-266	266	2.0	φ15.5	72.0±4	φ57	M34 P1	φ48	<i>φ</i> 60	1.4	0.3
BE-3-266	266	3.0	φ10.5	79.5±4	φ57	M34 P1	φ48	<i>φ</i> 60	1.4	0.3
BE-4-266	266	4.0	φ9.0	90.5±4	φ57	M34 P1	φ48	<i>φ</i> 60	1.4	0.3
BE-5-266	266	5.0	φ7.0	119.5±4	φ57	M34 P1	<i>φ</i> 48	<i>ф</i> 60	1.4	0.4
BE-7.5-266	266	7.5	φ4.5	129.0±4	φ57	M34 P1	<i>φ</i> 48	<i>φ</i> 60	1.4	0.4
BE-10-266	266	10.0	φ3.5	173.0±4	φ57	M34 P1	φ48	<i>φ</i> 60	1.4	0.4
BE-2-355	355	2.0	φ15.5	75.0±4	φ57	M34 P1	φ48	φ60	2	0.3
BE-3-355	355	3.0	<i>φ</i> 10.5	83.0±4	φ57	M34 P1	φ48	<i>φ</i> 60	2	0.3
BE-4-355	355	4.0	φ9.0	94.5±4	φ57	M34 P1	φ48	<i>φ</i> 60	2	0.3
BE-5-355	355	5.0	φ7.0	125.0±4	φ57	M34 P1	φ48	<i>φ</i> 60	2	0.4
BE-7.5-355	355	7.5	φ4.5	134.5±4	φ57	M34 P1	φ48	<i>φ</i> 60	2	0.4
BE-10-355	355	10.0	φ3.5	181.0±4	φ57	M34 P1	φ48	<i>φ</i> 60	2	0.5
BE-2-V	400 – 700	2.0	φ6.0	42.0+3	φ36	M22 P0.75	φ26	φ40	4	0.12
LBED-3	400 – 700	3.0	φ5.4	42.0+3	φ36	M22 P0.75	φ26	φ40	4	0.12
BE-4.1-V	400 – 700	4.1	φ4.1	62.0±3	φ36	M22 P0.75	φ26	<i>φ</i> 40	4	0.13
LBED-5	400 – 700	5.0	φ3.2	50.5±3	φ36	M22 P0.75	φ26	φ40	4	0.12
BE-6-V	400 – 700	6.0	φ4.3	102.0±3	φ36	M22 P0.75	φ36	φ40	4	0.17
BE-7.6-V	400 – 700	7.6	φ3.4	80.0±3	φ36	M22 P0.75	φ36	φ40	4	0.15
3E-8.4-V	400 – 700	8.4	φ3.1	89.5±3	φ36	M22 P0.75	φ36	φ40	4	0.16
LBED-10	440 – 700	10.0	φ2.6	109.5±3	φ36	M22 P0.75	φ36	φ40	4	0.18
BE-12.6-V	450 – 700	12.6	φ2.1	138.0±3	φ36	M22 P0.75	φ36	φ40	4	0.2
BE-14.3-V	460 – 700	14.3	φ1.8	158.5±3	φ36	M22 P0.75	φ36	φ40	4	0.2
BE-16.8-V	480 – 700	16.8	φ2.1	190.0±3	φ36	M22 P0.75	φ46	φ40	4	0.3
BE-18.5-V	500 – 700	18.5	φ1.9	211.0±3	 φ36	M22 P0.75	φ46	φ40	4	0.3
BE-21-V	510 – 700	21.0	φ1.7	241.0±3	 φ36	M22 P0.75	φ46	φ40	4	0.3
BE-1.5-LD	780 – 830	1.5	 φ16.1	51.0 ⁺⁴	φ57	M34 P1	φ48	φ60	4	0.3
BE-2-LD	780 – 830	2.0	φ15.3	53.0±4	<u>΄</u> φ57	M34 P1	φ48	φ60	4	0.3
 BE-3-LD	780 – 830	3.0	φ10.1	64.0±4	φ57	M34 P1	φ48	φ60	4	0.3
BE-4-LD	780 – 830	4.0	φ8.9	95.5±4	φ57	M34 P1	φ48	φ60	4	0.3
BE-5-LD	780 – 830	5.0	φ7.2	125.5±4	φ57	M34 P1	φ48	φ60	4	0.4
BE-7.5-LD	780 – 830	7.5	φ4.7	135.5±4	φ57	M34 P1	φ48	φ60	4	0.4
BE-10-LD	780 - 830	10.0	φ3.6	186.5±4	φ57	M34 P1	φ48	φ60	4	0.5
BE-1.5-1064	1064	1.5	φ16.0	52.0 ⁺⁴	φ57 φ57	M34 P1	φ48	φ60 φ60	4	0.3
LBED-2Y	1064	2.0	φ15.1	49.0 ⁺⁴	φ57 φ57	M34 P1	φ48	φ60 φ60	4	0.3
LBED-3Y	1064	3.0	φ10.2		φ57 φ57	M34 P1	φ48 φ48	φ60 φ60	4	0.3
LBED-4Y	1064	4.0	φ10.2	93.5±4	φ57 φ57	M34 P1	φ48	φ60 φ60	4	0.3
BE-5.3-1064	1064	5.3	φ6.8	127.5±4	φ57	M34 P1	φ48 φ48	φ60 φ60	4	0.3
BE-7-1064	1064	7.0	φ0.8 φ5.1	179.5±4	φ57 φ57	M34 P1	φ40 φ48	φ60 φ60	4	0.4
BE-10-1064	1064	10.0	φ3.6	188.5±4	φ57 φ57	M34 P1	φ48 φ48	φ60 φ60	4	0.5

* Laser pulse width 10ns, repetition frequency 20Hz

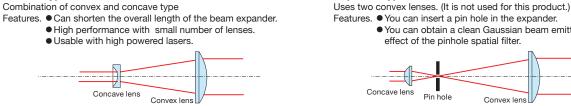
Lens configuration

Beam expander is divided into two main types depending on the configuration of the lens.

Galilean type

Combination of convex and concave type

Keplerian type





Convex lens Note: Do not use with high energy lasers It can cause a spark in the focal point of the laser causing the transmitted wave front to collapse.

Pin hole

Diopter and diopter correction function

By using the diopter correction function, it is available to adjust the divergent light beam to the parallel beam.

If it is necessary to use exact optical laser system, recommended to use the beam expander with diopter correction function.

And if the parallel light beam incident into the beam expander, the light would be emitted in expanded beam.

However, since most laser is slightly divergent, the beam will not be emitted by parallel beam.

In addition, parallel light emitted from the beam expander will be shifted in various factors. Such as LD (laser diode) which has a possibility that wavelength will change, and by the changes of the temperature.

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fe Lenses

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Laser Beam Expanders

• The visible type can be mounted directly to any He-Ne laser.

LBE

Beam expanders are useful laser accessories when the beam diameter must be increased. However, their main function is to decrease the divergence of the laser beams which are to be projected over long distances. These precision beam expanders have been designed for use with

HeNe lasers but they can be used for any laser working in the visible part of the spectrum (400 –

• Laser beam expanders designed to use with high powered lasers that are made of lenses attached together without

These beam expanders are light weight and short bodied and because they are Galileo type design, they have little



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- ► For wavelength or magnification which is not shown on-line or in the catalog, please ask our Sales Division.
- We provide the laser beam expander holders (KLH-BE) for opticalaxis adjustment of the laser beam expander.
 WEB Reference: Catalog Code W4147

Attention

- Make sure that the beam expander is well aligned with the laser light axis. If the beam expander is inclining, the output light will also be inclined.
- It is not possible to obtain a decreased beam diameter by using the beam expander on the opposite side. Use it properly to obtain an adequate optical solution.
- The light may not be collimated when it become divergent or convergent.

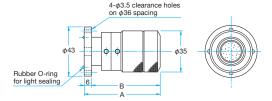
Outline Drawing

#4-40UNC, L=3/8...4

700nm).

using glue (air-gap).

aberration and correction.



Typical Laser for He-N	le (400 – 700nm))			Prima Finish	ry material: Alumin I: Black Anodized
Part Number	Expansion ratio	Barrel length A [mm]	B [mm]	Input aperture [mm]	Laser Damage Threshold* [J/cm ²]	Weight [kg]
LBE-3	3	62.9	56.9	φ3.8	4	0.12
LBE-5	5	61.9	55.9	φ2.7	4	0.12
LBE-10	10	127.9	121.9	φ1.7	4	0.18

Laser pulse width 10ns, repetition frequency 20Hz

Typical Laser for LD (7	780 – 830nm)					ary material: Aluminu n: Black Anodized
Part Number	Expansion ratio	Barrel length A [mm]	B [mm]	Input aperture [mm]	Laser Damage Threshold* [J/cm ²]	Weight [kg]
LBE-3L	3	63.3	57.3	<i>\$</i> 3.8	4	0.12
LBE-5L	5	62.3	56.3	φ2.7	4	0.12
LBE-10L	10	127.9	122.8	φ1.7	4	0.18

* Laser pulse width 10ns, repetition frequency 20Hz

Typical Laser for YAG	(1064nm)					ry material: Aluminum : Black Anodized
Part Number	Expansion ratio	Barrel length A [mm]	B [mm]	Input aperture [mm]	Laser Damage Threshold* [J/cm ²]	Weight [kg]
LBE-3Y	3	63.73	57.8	φ3.8	4	0.12
LBE-5Y	5	62.7	57.8	φ2.7	4	0.12
LBE-10Y	10	128.9	123.8	φ1.7	4	0.18

* Laser pulse width 10ns, repetition frequency 20Hz

Compatible Optic Mounts

KLH-BE-M22H

Catalog Code W3809

Application Systems

&

	• • • • • • • • • • • • •	Entry and shares
Contact sheet for	Laser Beam	Expanders

Estimation Order

Date

To: Sigma Koki Co., Ltd. **FAX +81-3-5638-6550** Γ

Affiliation (Organization Name)								O p	otics & otical oatings
Department				Name				Op	to-
TEL		FAX		1	E-mail			Me	echanics
Country/Address	;		<u> </u>					Ba	ISES
Name & Designation							(Tentative name is okay)		anual
Drawing Number				Estimate	Yes: by [Date		Sta	ages
Desired Delivery Date				Budget			JP Yen		tuators & ljusters
				* Please ent		e and Dimensions		Sta	otoeized ages ht Sources &
									er Safety dex
								Guide	÷
Intention								Mirro	
								Beam	nsplitters
								Polari	izers
								Lense	es
								Multi-E	lement Optics
								Filter	s
								Prism	IS
Quantity						Other		Substra	ates/Windows
Wavelenght Used	$\lambda =$		nm	* Write more	detailed specifica		llustration is acceptable.)	Optic	al Data
Wavelengin Useu				-	·			Maint	tenance
Divergence	F =								
angle of beam			mrad	-				Selec	tion Guide
Beam incident									omats
diameter			mm					focus	sing Lenses nses
Magnification				-				Objec	
of afocal								Expa	nders
) /			-				Other	S
Transmitted wavefront	λ/			-					
Type of lens	☐ Galilean type☐ Keplerian type								
Ciama Kaki (Concert Costale a 00		

Sigma Koki Co., Ltd.

General Catalog 02





f*θ*-10600



The f theta lens for CO_2 laser is made by a single lens of zinc selenide (ZnSe). These are used in the laser marking systems.

- It is compact and lightweight because it is composed of a single lens.
 - The design and use are processed to an optimum shape of various aberrations becomes smaller.

L

Focal plane

• There are wide variety of the lineup that scan area is 50mm to 300mm.

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Specifications	
Material	Zinc selenide (ZnSe)
Design wavelength	10.6µm
Entrance pupil diameter	φ12mm
Scanning angle	±12.5°
Distance to lens from pupil	25mm
Coating	Dielectric multi-layer coating

Guide

We also offer f theta lens in other than CO₂ laser wavelength of 10.6um. Refe nce B186

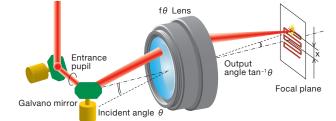
Attention

- When light is condensed on the surface of ZnSe, the high power laser beam may produce toxic gases due to the thermal decomposition.

In addition, a large amount of gas and powder occurs when the ZnSe lens is damaged by the laser thermal runaway. In case of the ZnSe lens is damaged by any chance, DO NOT handle the lens with your bare hands. Collect the debris and be careful not to inhale the powder and steam generated.

- It is not recommended to use the f theta lens for the optical imaging system because it is designed for the scanning system.
- Please place in accordance with the position of the entrance pupil of the f θ lens beam scanning system (galvanometer mirror). If the incident pupil is not in position of the beam scanning system, the optimum focusing spot cannot be achieved because the aberration will increase.

Schematic



φ90

By using the f theta lens, it is possible to be moved a laser light spot in constant speed linear motion on the focal plane by scanning the mirrors such as galvanometer scanner mirrors.

The f theta lens enables this by the effect of distortion.

Mathmatically it is expressed as following;

focal length = "f", ideal image height = "y", the angle of scanned = " θ " therefore, $y = f\theta$.

In the normal single lens, the ideal image height "y" is represented by $v = f \tan \theta$.

Characteristics of both are the same in a small angle range. However, the difference is greater angle increases.

Selection Guide **Achromats** Focusing Lenses fe Lenses

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Specifications			
Part Number	Focal length f [mm]	Scanning Range [mm]	WD [mm]
fθ-75-10600	75	50×50	57.8
fθ-100-10600	100	70×70	85.8
fθ-150-10600	150	110×110	139.0
f <i>θ</i> -200-10600	200	140×140	181.2
fθ-250-10600	250	175×175	232.7
fθ-300-10600	300	210×210	283.6
fθ-340-10600	340	250×250	344.7
f <i>θ</i> -400-10600	400	300×300	414.5

Important: Treatment of ZnSe optics
Important: Treatment of ZnSe optics ZnSe (Zinc selenide) is Poisonous and Deleterious Substances classified as legal, Depending on the specifications, the certificate of delivery may be required acquisition of Poisonous and Deleterious Substances.
In addition, ZnSe Optics disposal after use is prohibited. When lenses that are no longer needed, please return them to us. However, it is only in our products. The above is a case in Japan and

please ask your local sales contact about requirements outside Japan.

Hydrogen selenium is harmful when it comes to contact with strong acids! Do not immerse the lens in hydrochloric or sulphuric acid.





This is a beam expander for CO₂ Laser (wavelength : 10.6µm) made of zinc selenide (ZnSe) lens. It will be used in laser marking system and so on.

- Diopter correction function is provided, customer can fine-tune the collimated beam.
- Because it is a beam expander type of the Galilean, it is compact and has good aberration characteristics.
- Since the lens of zinc selenide has an anti-reflection coating, loss of light intensity is kept low.



		Coatings		
Specifications		Opto-		
Material	Zinc selenide (ZnSe)	Mechanics		
Design wavelength	10.6µm			
Coating	Dielectric multi-layer coating	Bases		
Transmittance	>98.5%	Dases		
		Manual		
Guide	Guide			
Beam expanders of	her than for CO₂ laser (10.6µm) are available.	Stages		
Reference B200				
We provide the lase	Actuators & Adjusters			
WEB Reference Catalog Code	he laser beam expander. W4147			
Attention				
		Stages		
	obtain a decreased beam diameter by using the the opposite side. Use it properly to obtain an			
adequate optical so	Light Sources & Laser Safety			
	beam expander is well aligned with the laser light			
axis. If the beam ex inclined.	pander is inclining, the output light will also be			
inclined.	Index			

Outline Drawing

φA M22 P0.75		φB
	С	
	D	

Part Number	φA [mm]	φB [mm]	C [mm]	D [mm]
BE-10600-3	φ25	φ25	50	65
BE-10600-4	φ25	φ25	55	75
BE-10600-5	φ30	φ30	58	78

Specifications						
Part Number	Expansion ratio	Input aperture (MAX) [mm]	Output Clear aperture [mm]	Diameter [mm]		
BE-10600-3	3	φ4	φ12	φ25		
BE-10600-4	4	φ4	<i>φ</i> 16	φ25		
BE-10600-5	5	φ4	φ20	φ30		

Important: Treatment of ZnSe optics

Important: Treatment of ZnSe optics

ZnSe (Zinc selenide) is Poisonous and Deleterious Substances classified as legal, Depending on the specifications, the certificate of delivery may be required acquisition of Poisonous and Deleterious Substances.

In addition, ZnSe Optics disposal after use is prohibited. When lenses that are no longer needed, please return them to us. However, it is only in our products. The above is a case in Japan and please ask your local sales contact about requirements outside Japan.

Compatible Optic Mounts

KLH-BE-M22H

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